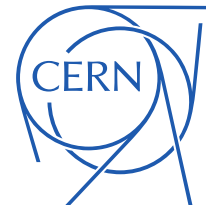


OTR/ODR emittance measurement system at ATF2

M. Bergamaschi^{1,2}, A. Aryshev³, P. Karataev¹,
R. Kieffer², T. Lefevre², S. Mazzoni², N. Terunuma³

CLIC Workshop 2018, CERN, 23rd January 2018

1. John Adams Institute at Royal Holloway, Egham, United Kingdom
2. CERN European Organisation for Nuclear Research, Geneva, Switzerland
3. KEK High Energy Accelerator Research Organization, Tsukuba, Japan



Outline

- Project Overview
- ODRI experiment at ATF2
- Operational year 2017 ODRI results at ATF2
- Summary and outlook

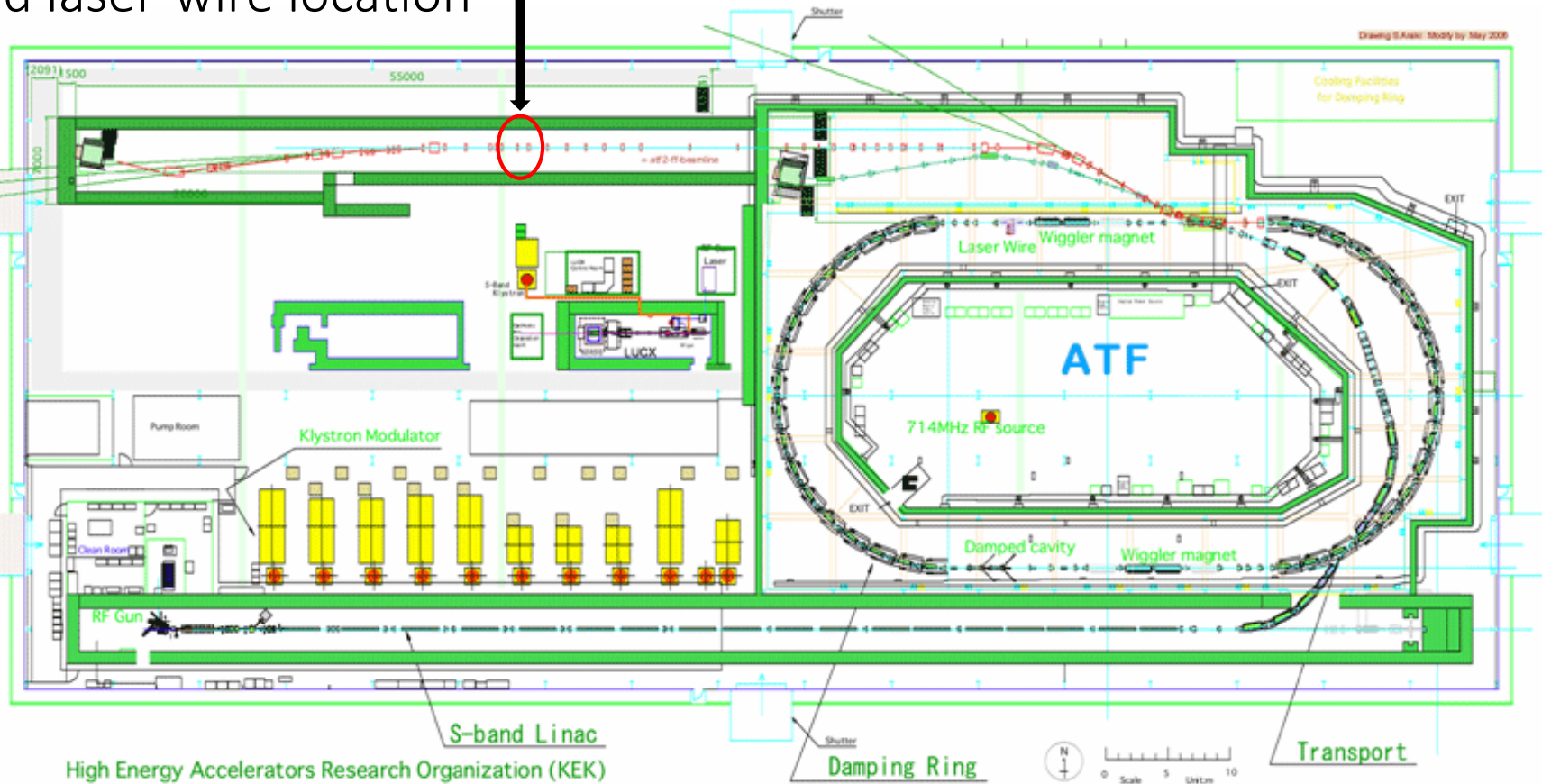
Overview

Motivations and Goals:

- Develop a non-invasive transverse profile station for CLIC/ILC beams with micron resolution
- Develop, install and test a combined Optical Transition Radiation (OTR) and Optical Diffraction Radiation Interference (ODRI) emittance station at ATF2 at High Energy Accelerator Research Organisation (KEK)
- To optimize sensitivity to smallest beam sizes, we plan to observe ODRI in the visible and far-UV wavelength range, down to approximately 200 nm

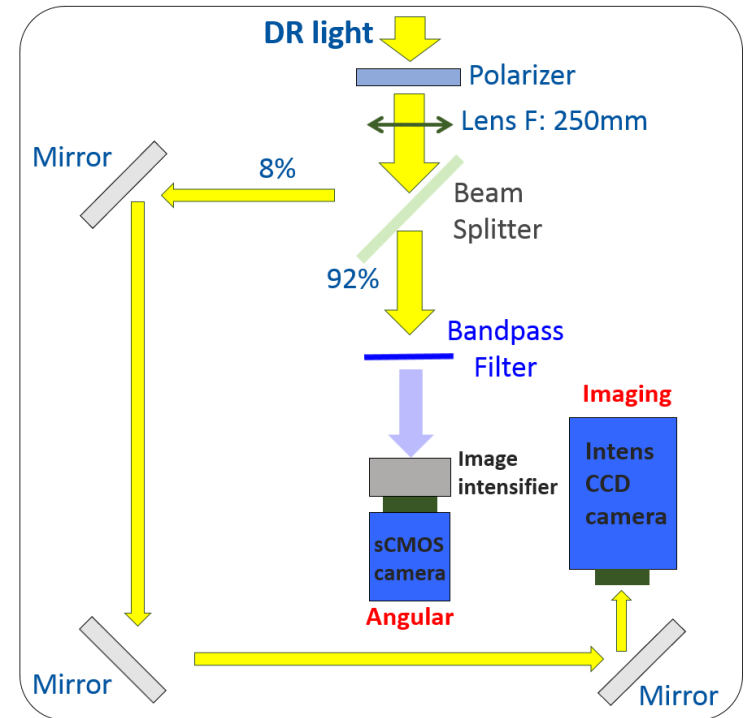
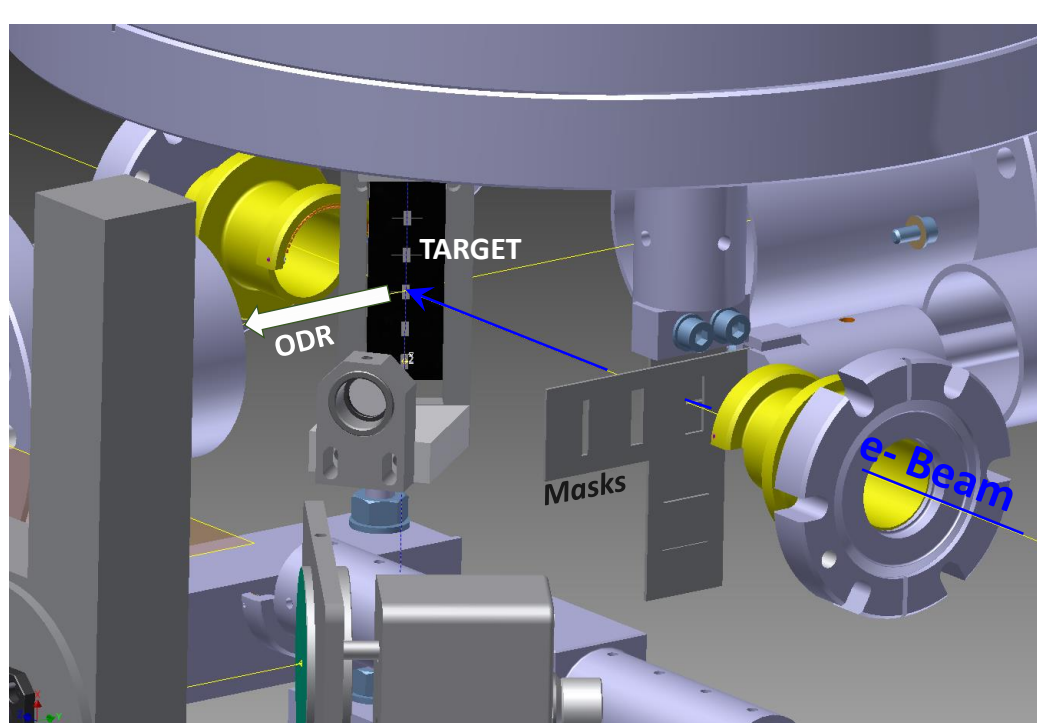
ODRI experiment at KEK ATF2

ODRI experiment location between QM14FF and QM13FF
old laser-wire location

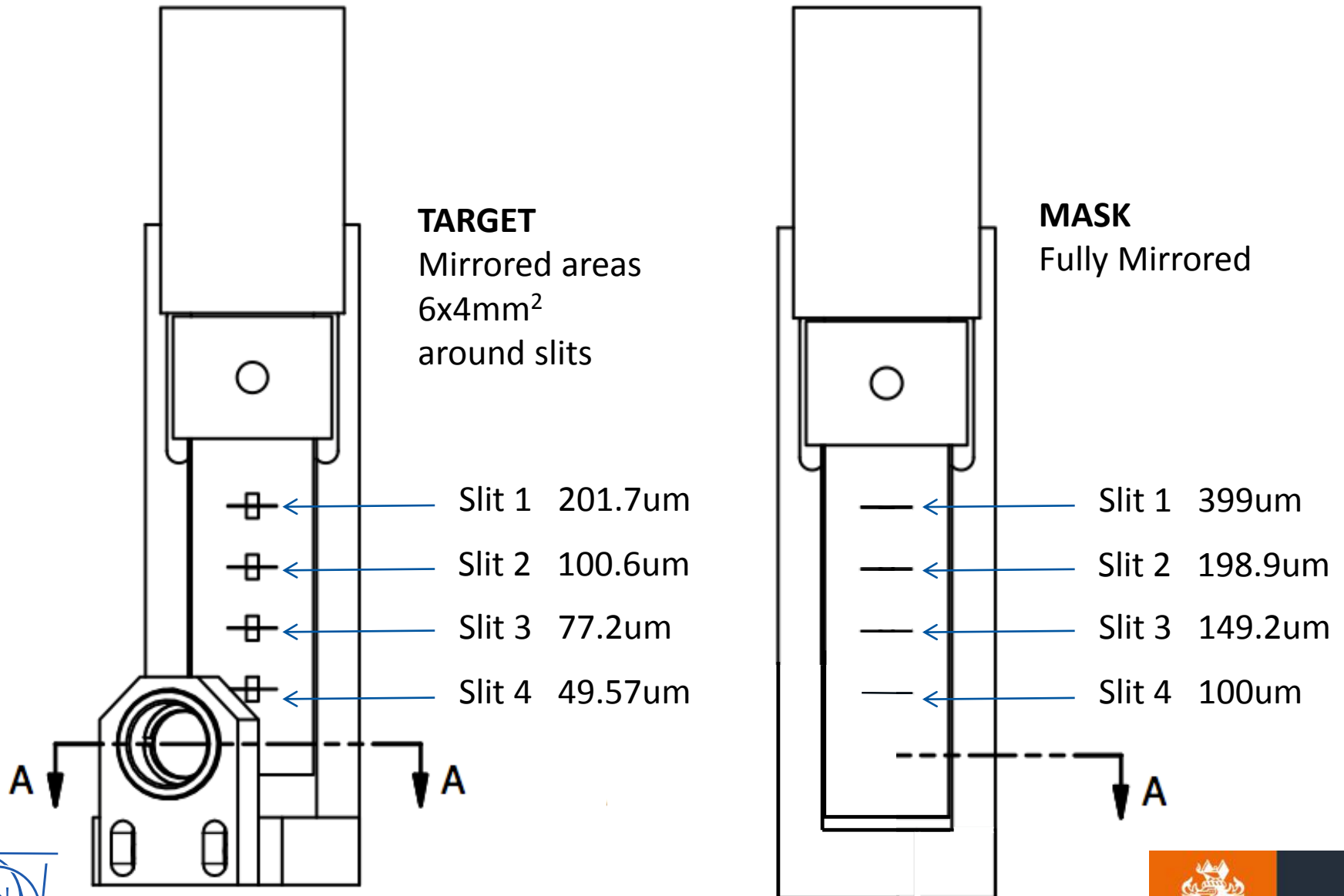


ODRI experiment at ATF2

- The **target** has **4 slits for DR (50 to 201 μm)**
- A couple of vertical and horizontal **mask slits** can be inserted 13 cm upstream the target



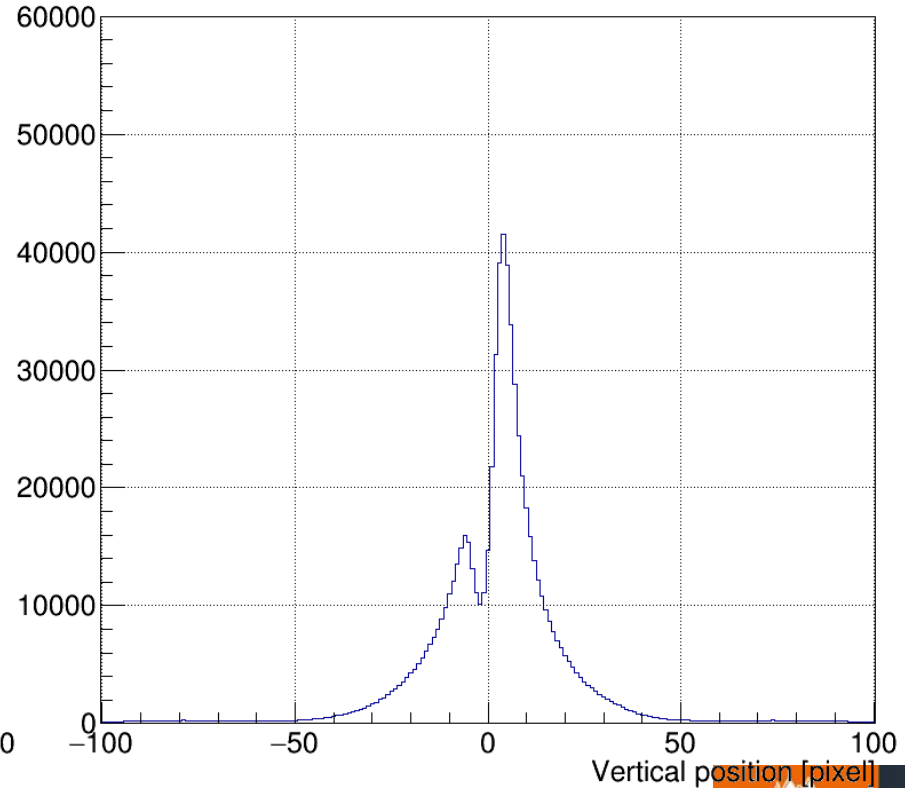
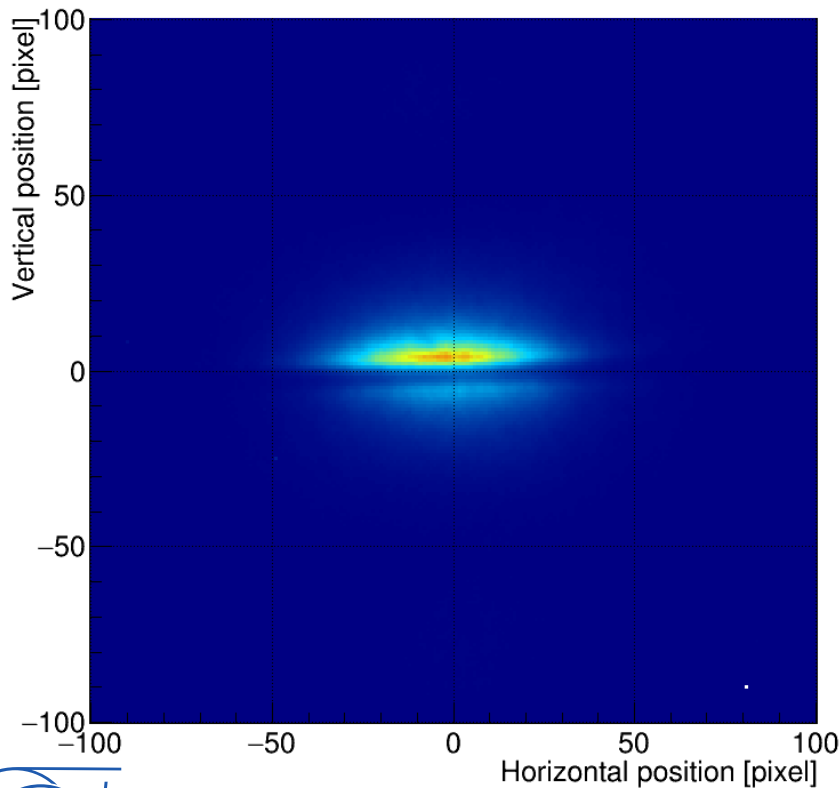
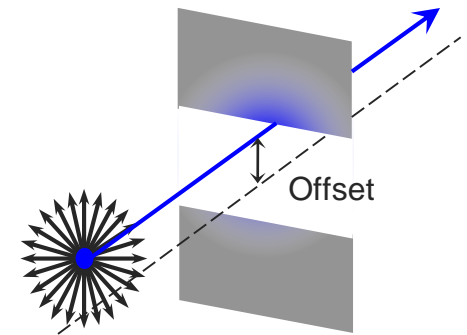
ODRI experiment at ATF2



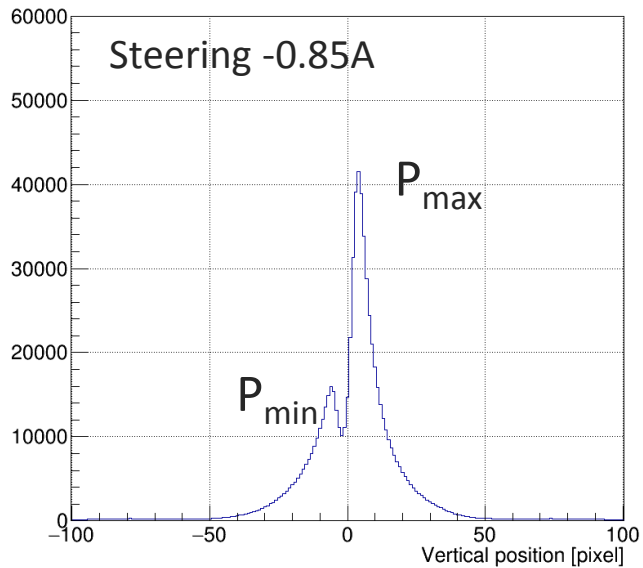
ODR in imaging

There is **no visible beam size dependency** of the pattern in **imaging**.

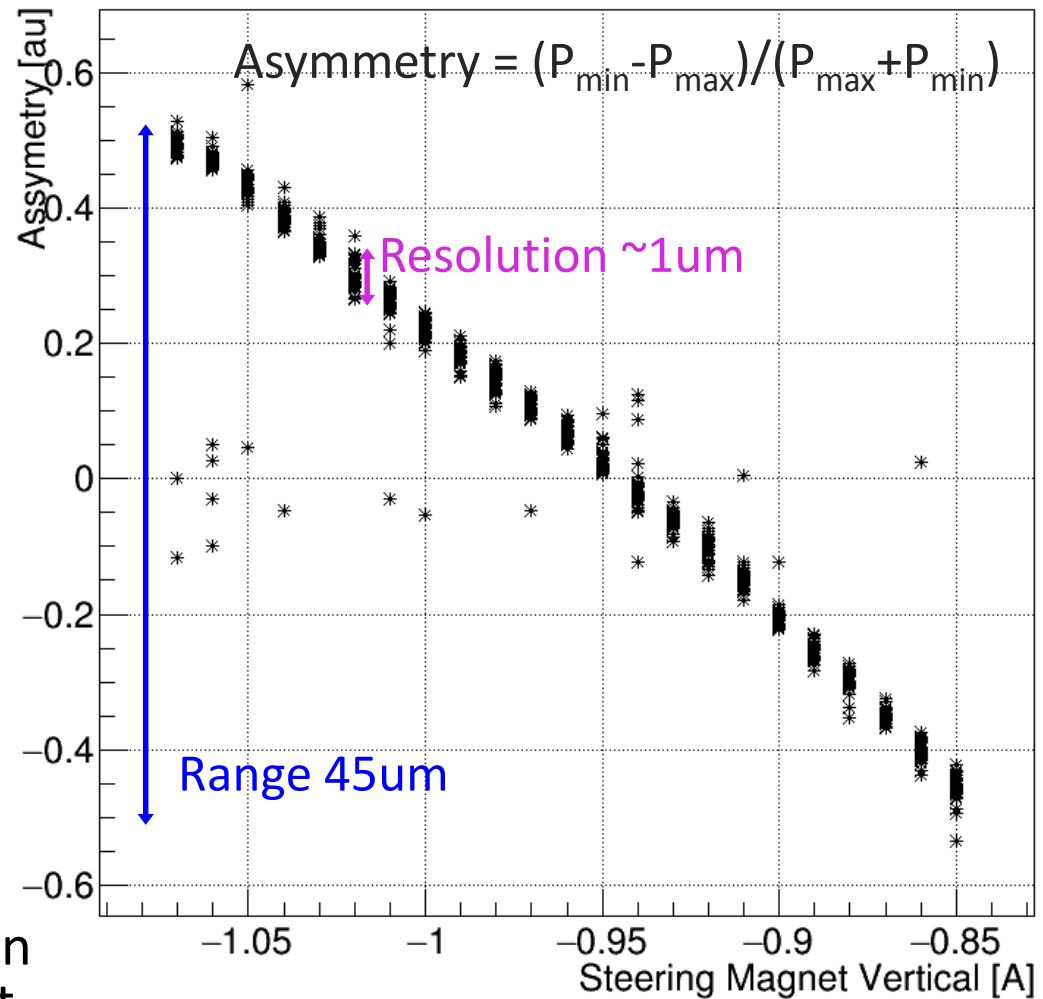
But the **vertical position** into the slit changes the profile **asymmetry** => **Optical Beam Position Monitor (BPM)**



ODR imaging as an optical BPM

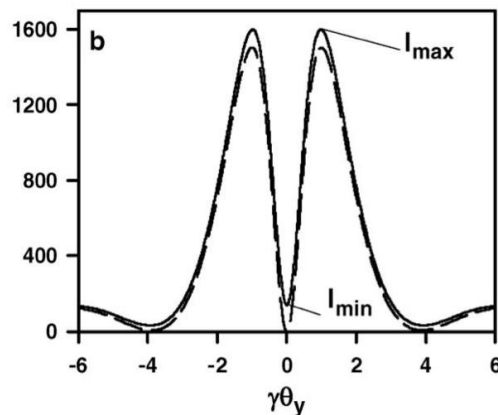
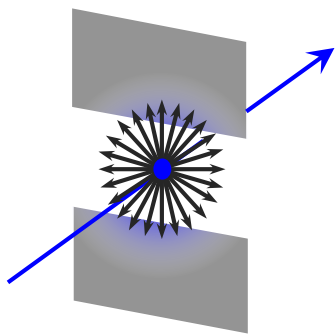


- Slit: **56 μm**
- Beam size: **1 μm**
- 30 shots statistics
- **Position resolution: about 1 μm**
- Steering magnet to scan the beam inside the slit



ODR for beam size measurements

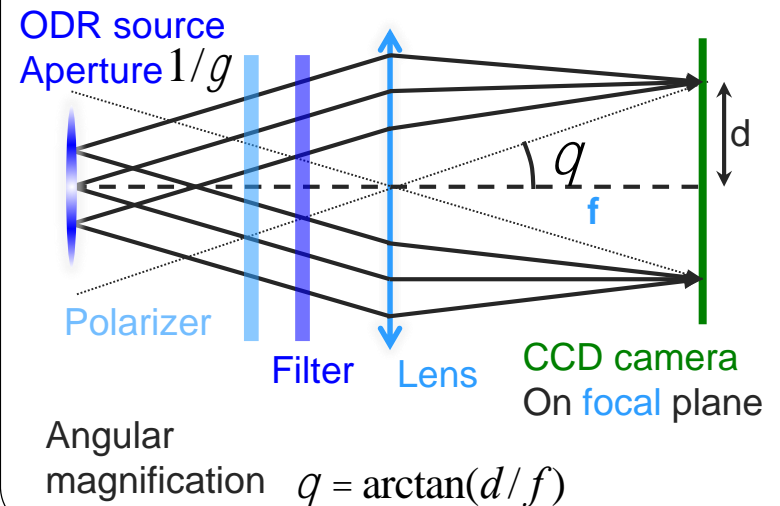
The **beam size** is extracted from the **visibility** I_{\min}/I_{\max} of the projected vertical component of the ODR **angular distribution**



An **horizontal slit** is used to measure a **vertical beam size**.

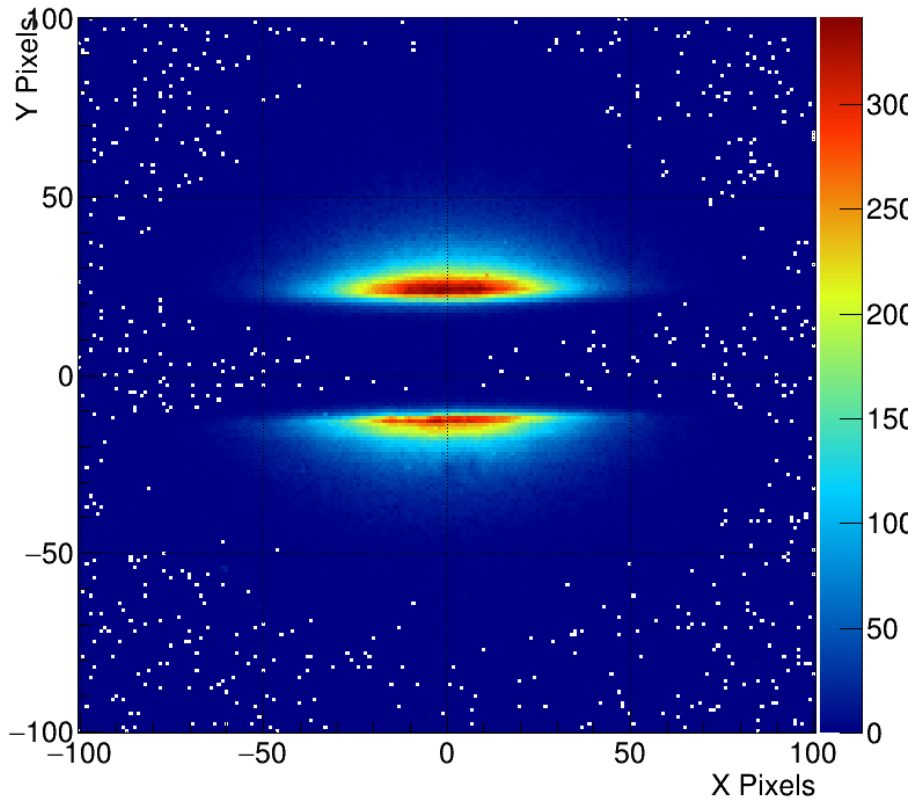
We use a polarizer to select only the **vertically polarized ODR photons** and 40nm BW filters to select the **wavelength**

The **angular distribution** is obtained using a camera located at the back focal plane of an optical **lens** (effective infinity)

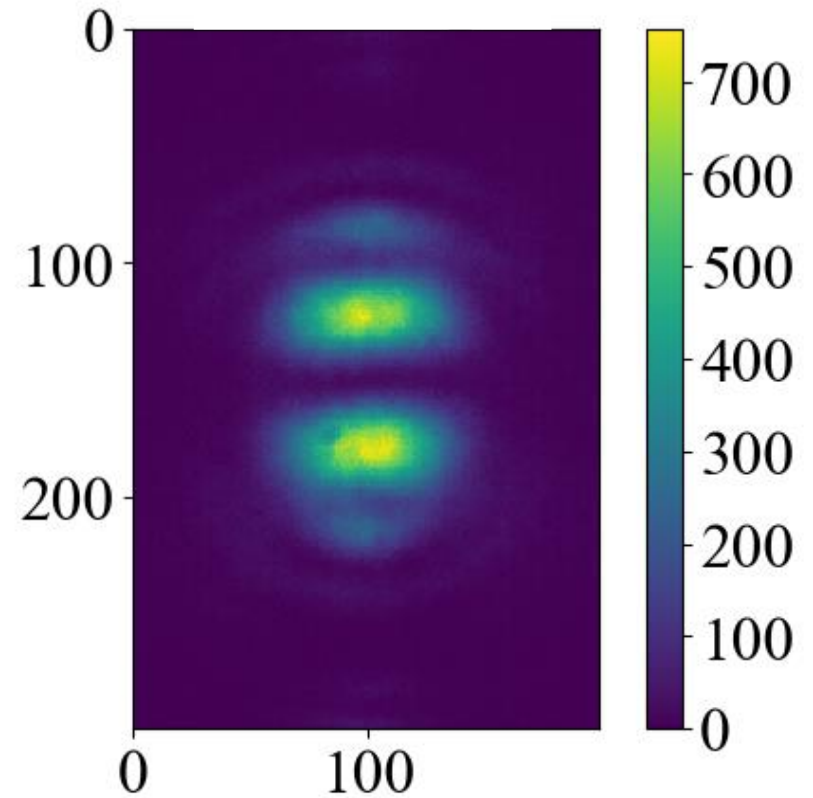


ODRI at ATF2

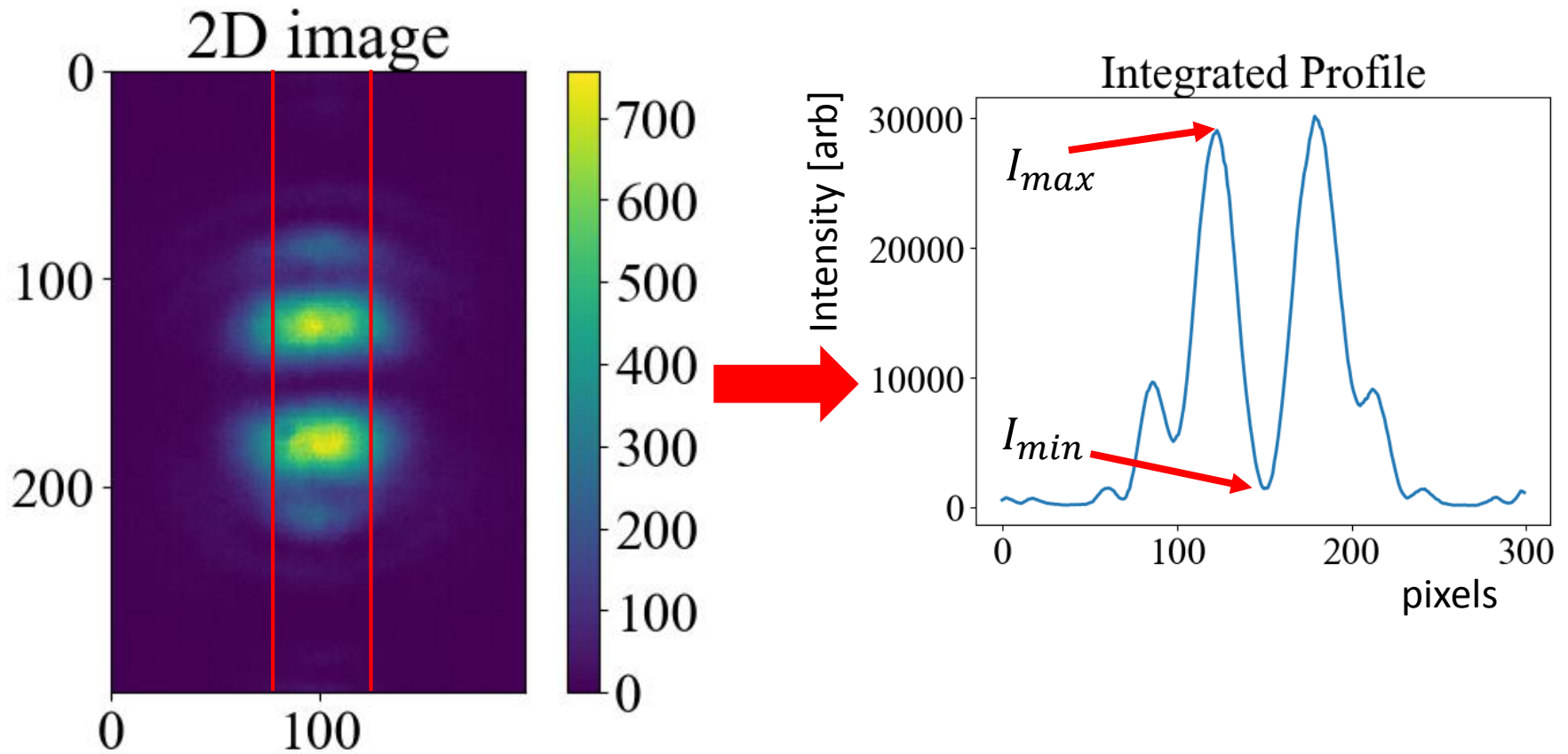
Direct Image of the ODR1



2D Angular distribution of the ODR1



ODRI at ATF2

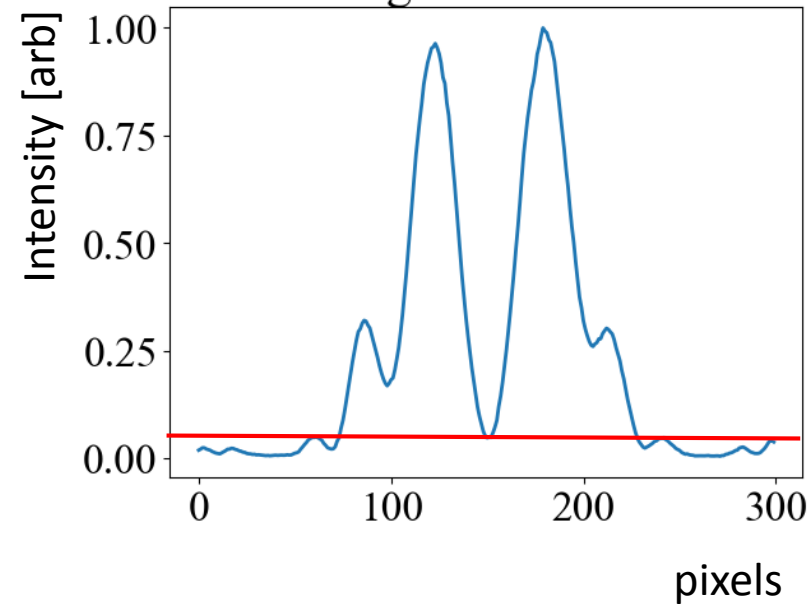


ODRI at ATF2

mask = 100.0 μm , target = 49.7 μm , same beam condition

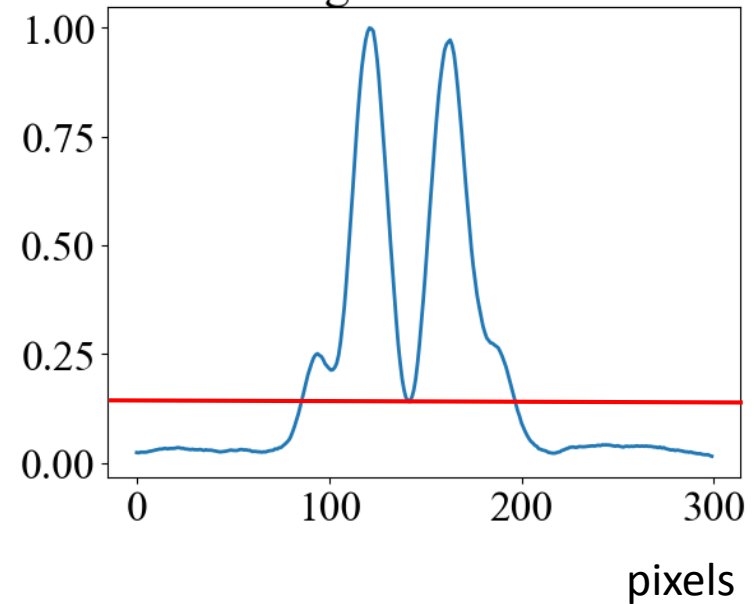
$\lambda = 400 \text{ nm}$

Integrated Profile



$\lambda = 250 \text{ nm}$

Integrated Profile

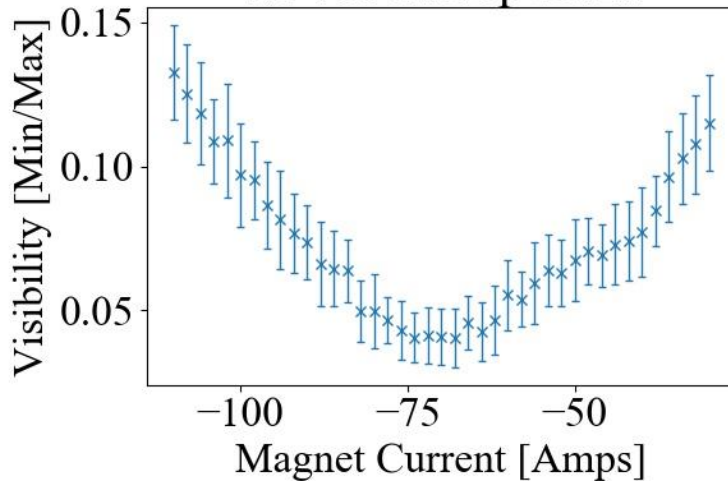


ODRI at ATF2

Quadrupole scan around beam waist

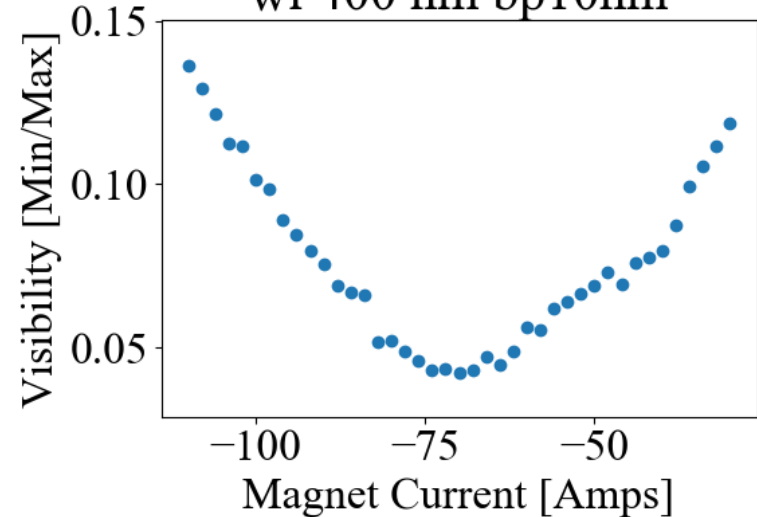
Single image acquisition

wl 400 nm bp10nm

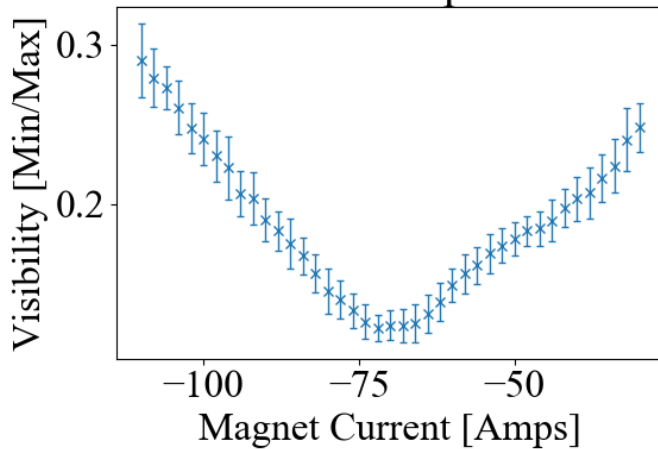


Averaged image over 100 pulses

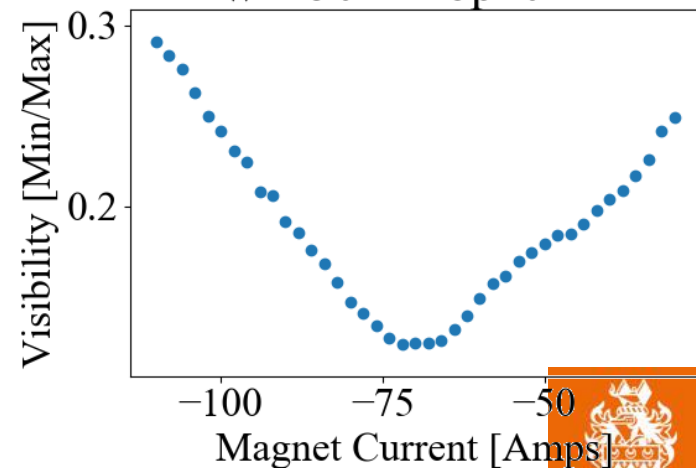
wl 400 nm bp10nm



wl 250 nm bp40nm



wl 250 nm bp40nm

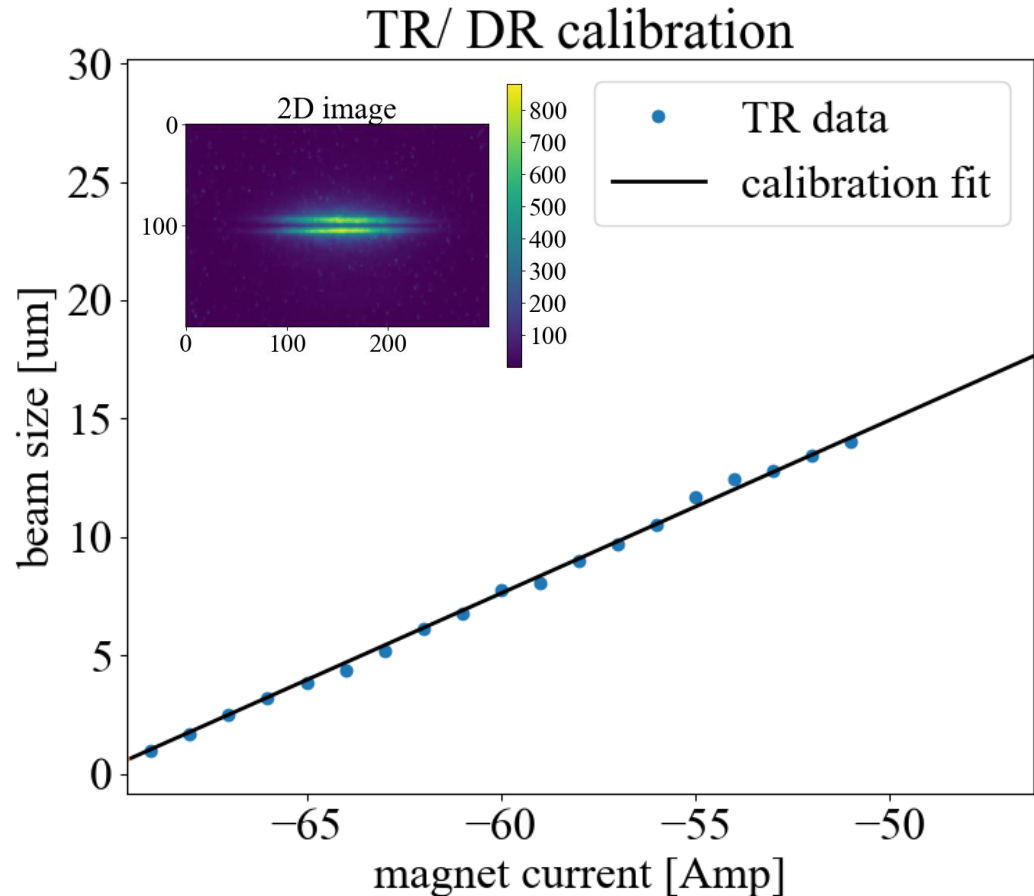


OTR Beam size calibration

The side mirrors of the ODR slit were used to record reference TR beam size measurement using PSF technique¹

OTR PSF could be used in CLIC/ILC with single bunch.

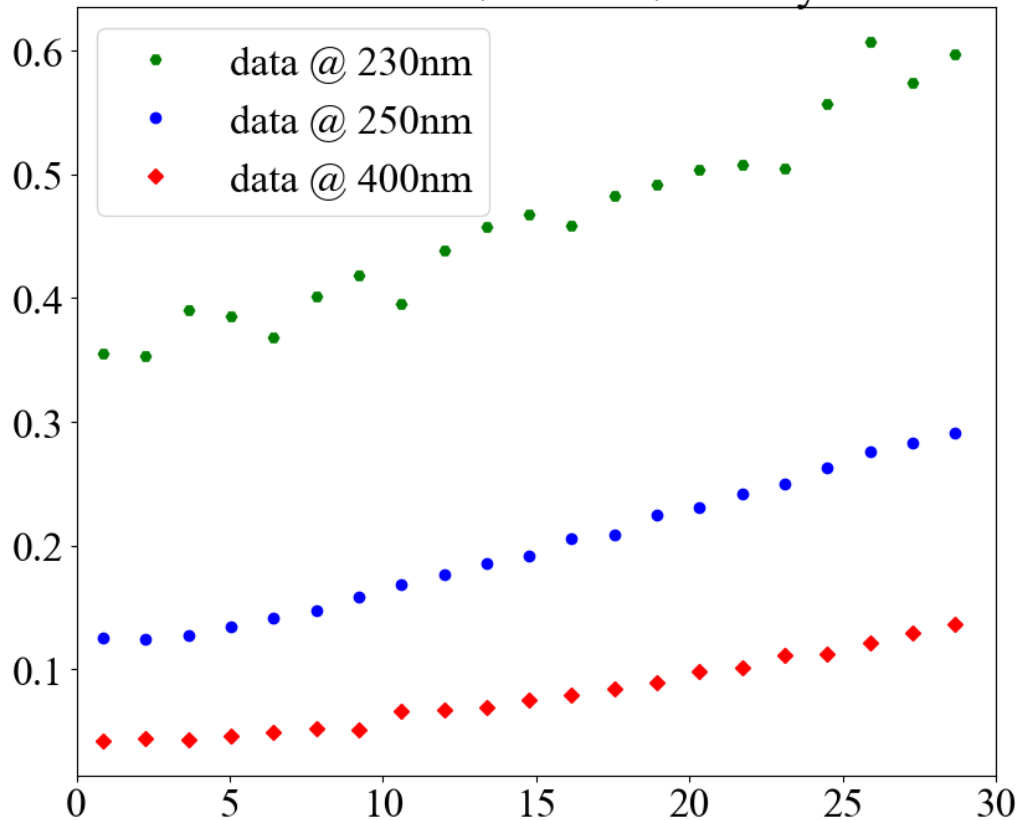
Then ODR can be used for full beam charge.



1. Very high resolution optical transition radiation imaging system: Comparison between simulation and experiment, B. Bolzon et al., 2015, Physical Review Special Topics - Accelerators and Beams , 18

ODRI at ATF2

Beam size vs ODR visibility



As expected sensitivity increase with decreasing wavelength, good sensitivity for UV down to 5 micrometers.

Previous measurements minimum was $14 \mu m^2$

mask = $100.0 \mu m$, target = $49.7 \mu m$

Summary

2017 ODRI Achievements

- Imaging the DR source to monitor the position of the beam during angular data acquisition => **beam in the slit centre**
- Data successfully collected also in the far UV (230/250nm)
- **Sensitivity to micrometer scale beam size** has been demonstrated down to 5 μm
- **Beam orbit optimisation** needed to minimize SR contribution
- **Mask** contribution to **block SR** has been observed

Outlook

- Reproduce measurement for small beam size during February operations:
 - DR in the visible and UV
 - Cross-calibration with OTR PSF for micron size beam
- Test of horizontal mask to reduce SR contribution
- Test of iris on the lenses to reduce background light from other mirrors on target

Thank you for your attention!

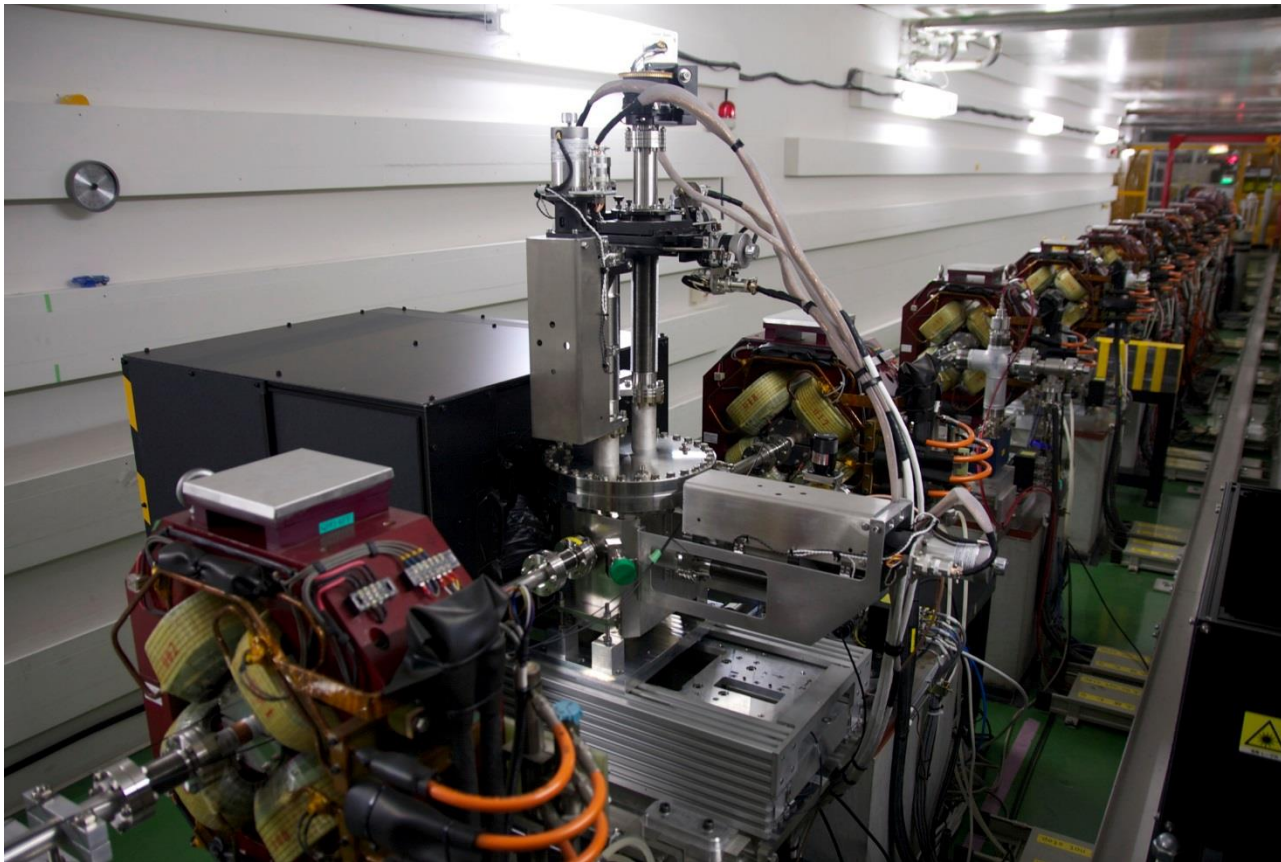


Back-up slides



ODRI experiment at KEK ATF2

Experiment installed at ATF2 in February 2016, in the laser-wire previous location where vertical beam can be focused to $< 1\mu\text{m}$



ODRI experiment at KEK ATF2

45deg View Port
Target laser alignment

45deg View Port
Mask

Target
Actuator

Mask
Actuators

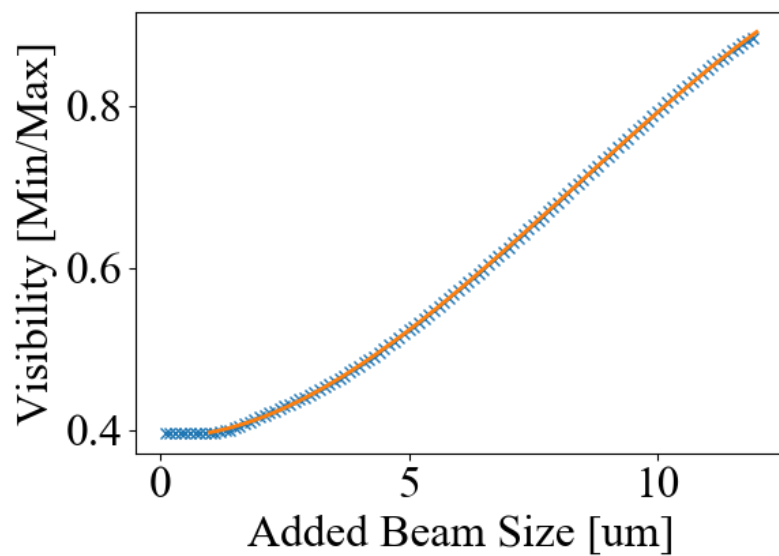
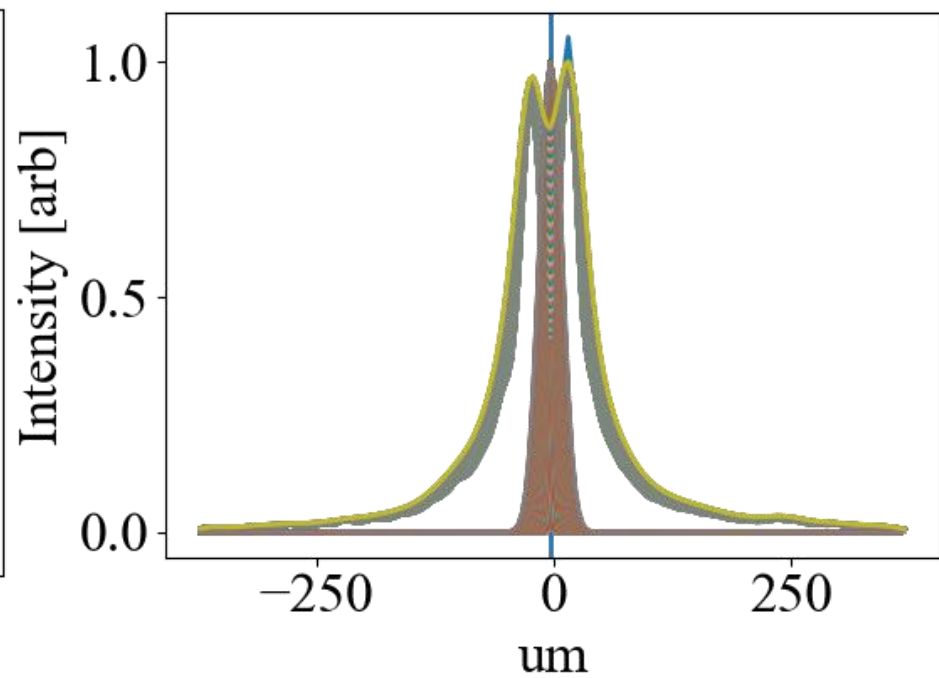
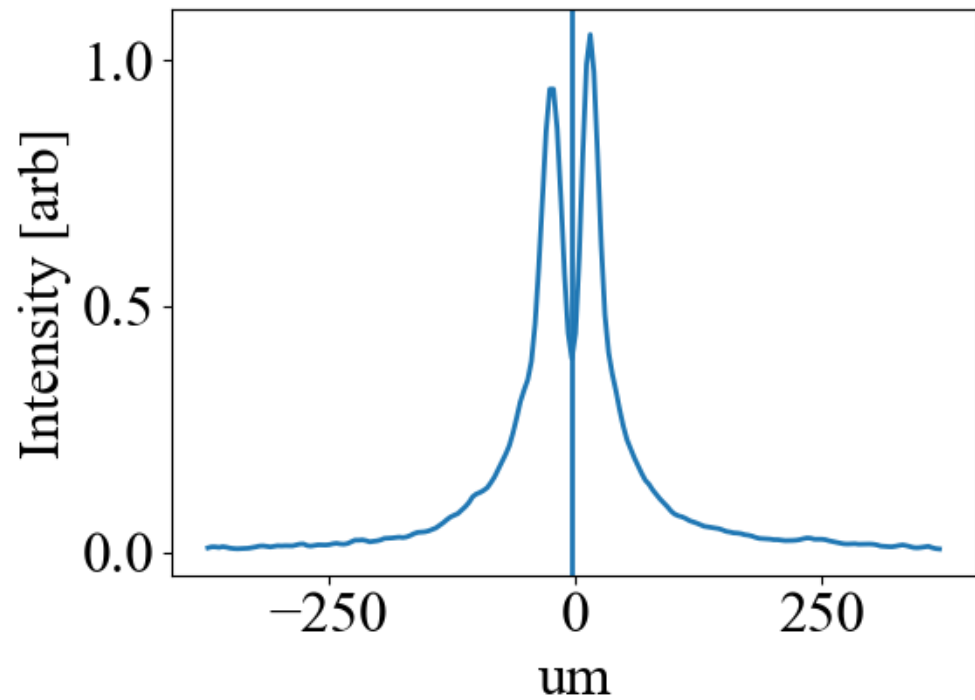
Replacement
chamber

Beam

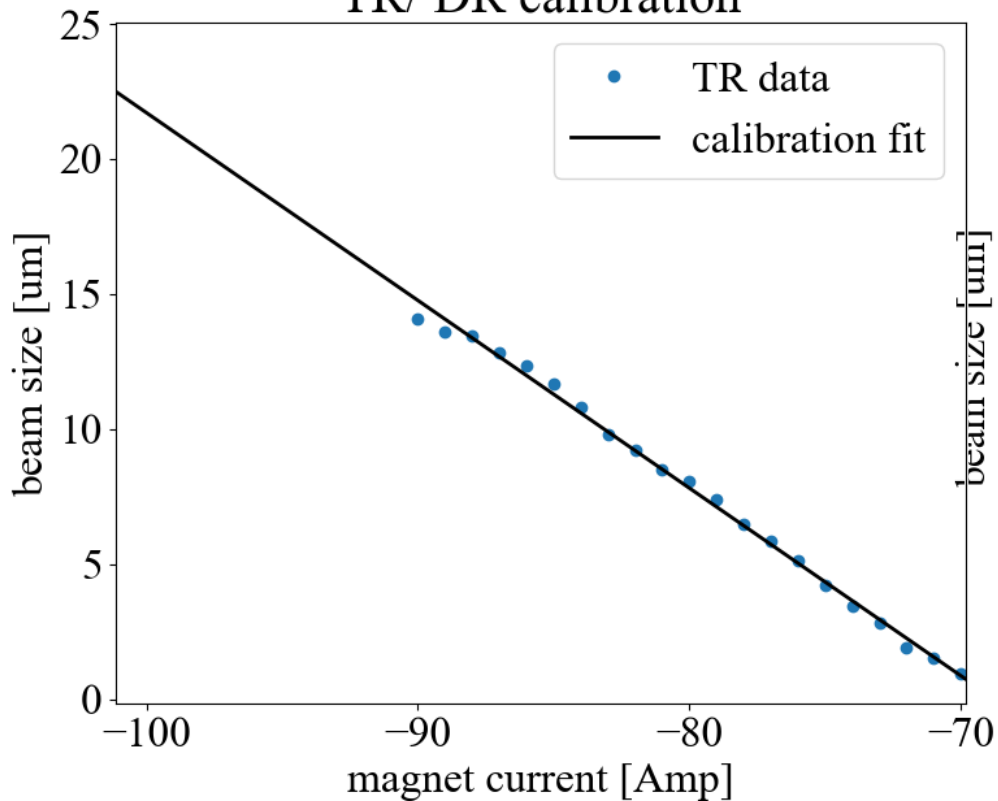
Input
Flange
(Beam)

90 degrees
View Port on target
(DR imaging and far-field)

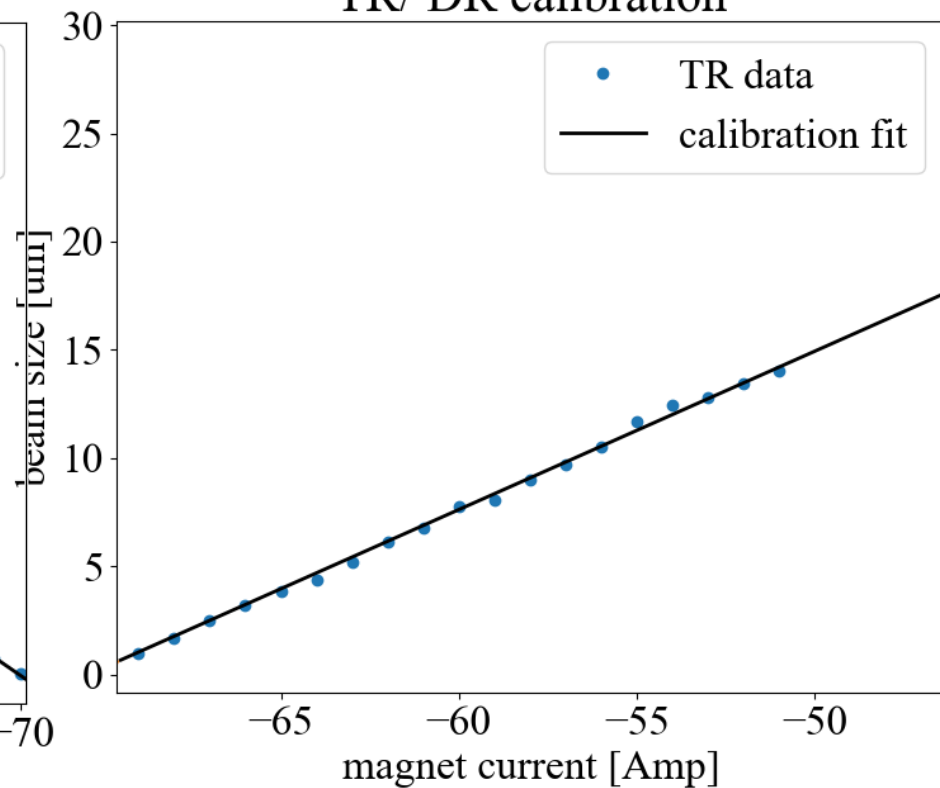
40 degrees
View Port on target
(TR imaging)



TR/ DR calibration



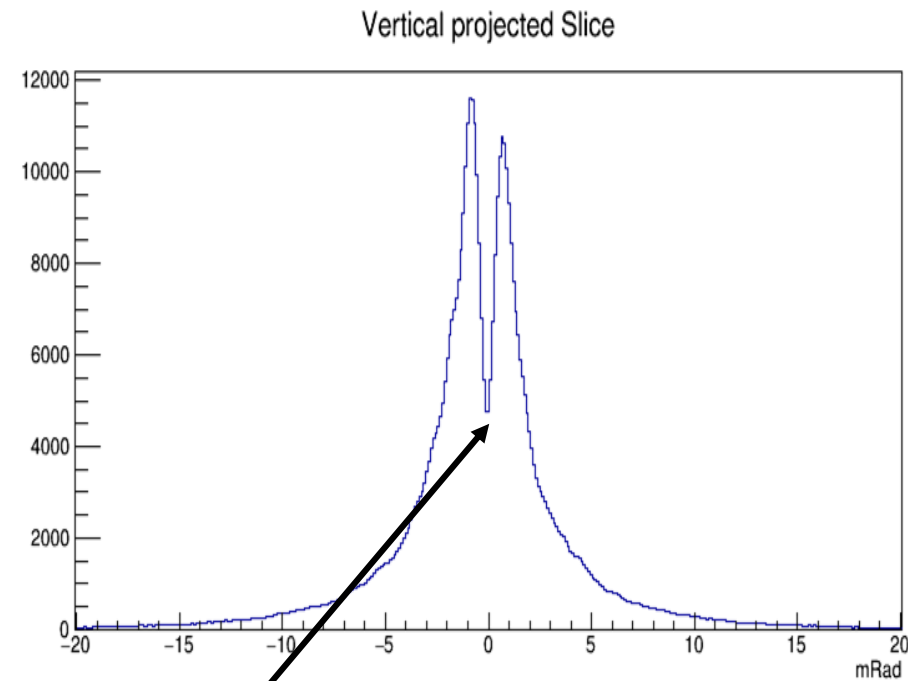
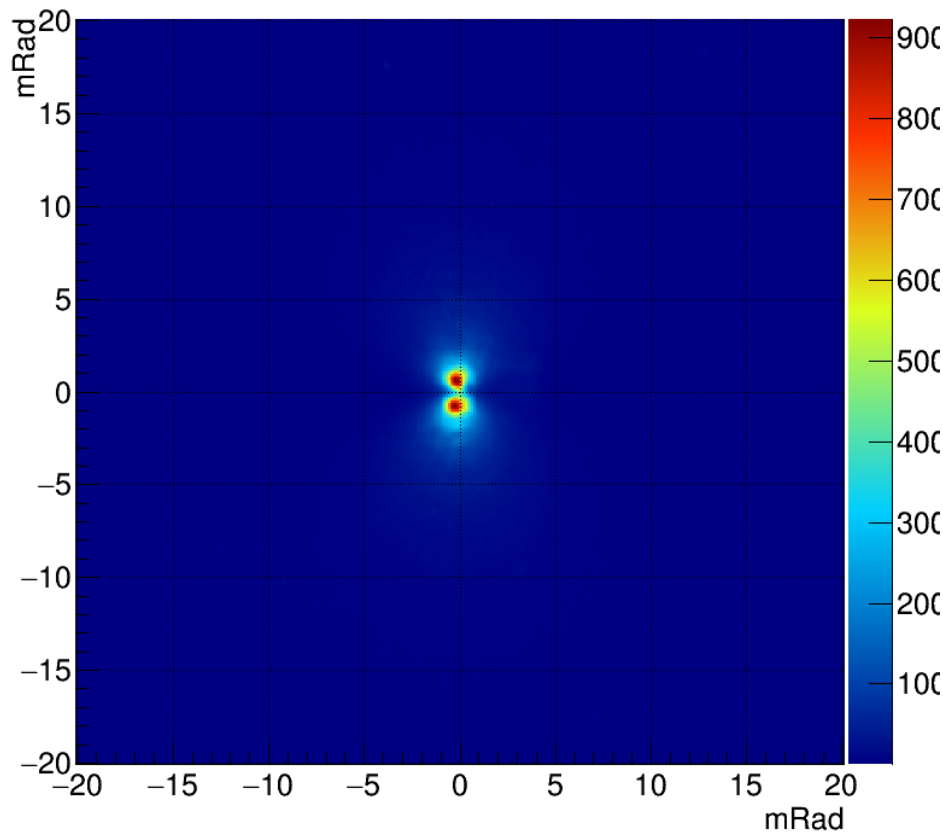
TR/ DR calibration



Synchrotron Radiation Contribution at ATF2

Observation of the angular pattern with target in the **OTR** position with mask inserted to evaluate **Synchrotron Radiation Contribution**

Angular distribution



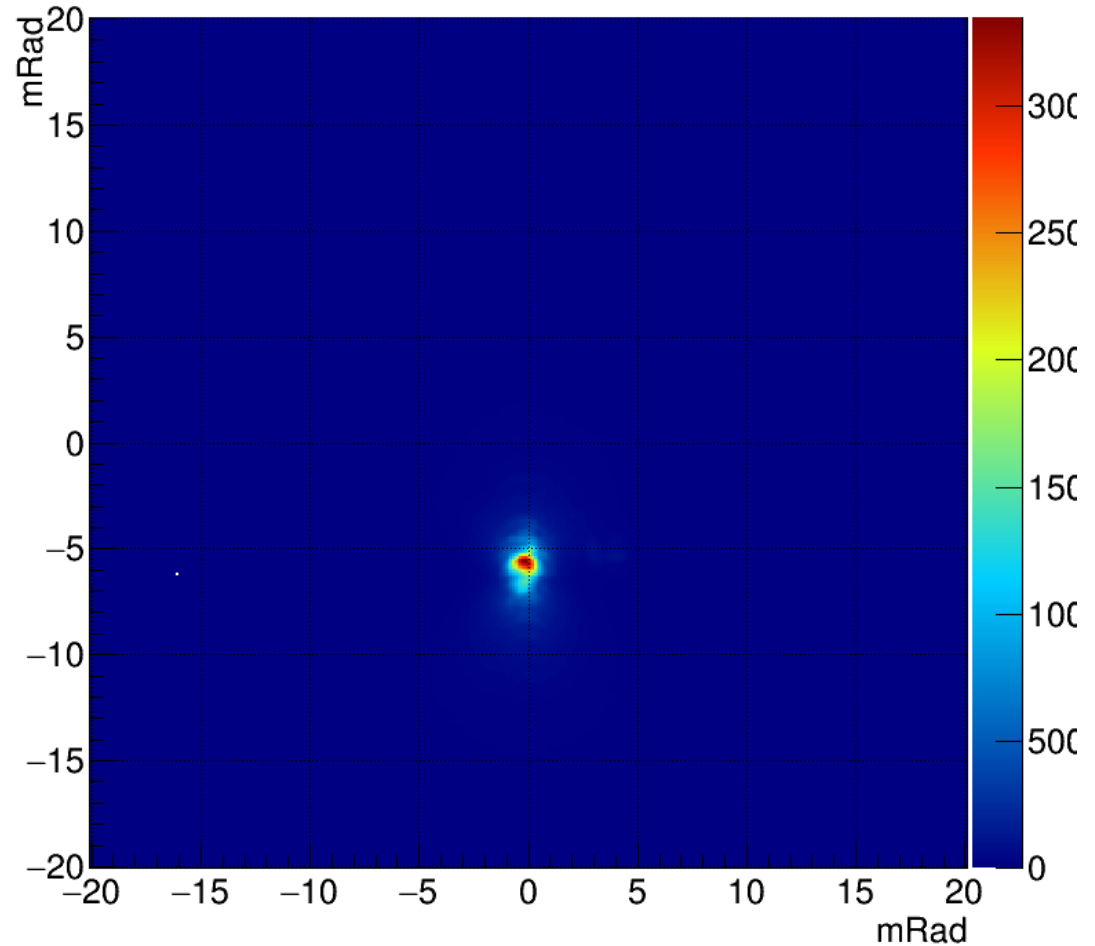
Minimum too high = high SR Contribution

Synchrotron Radiation Contribution at ATF2

Angular distribution

OTR Angular pattern with steering magnet off and without mask

Strong Contribution, impossible to evaluate the TR angular pattern

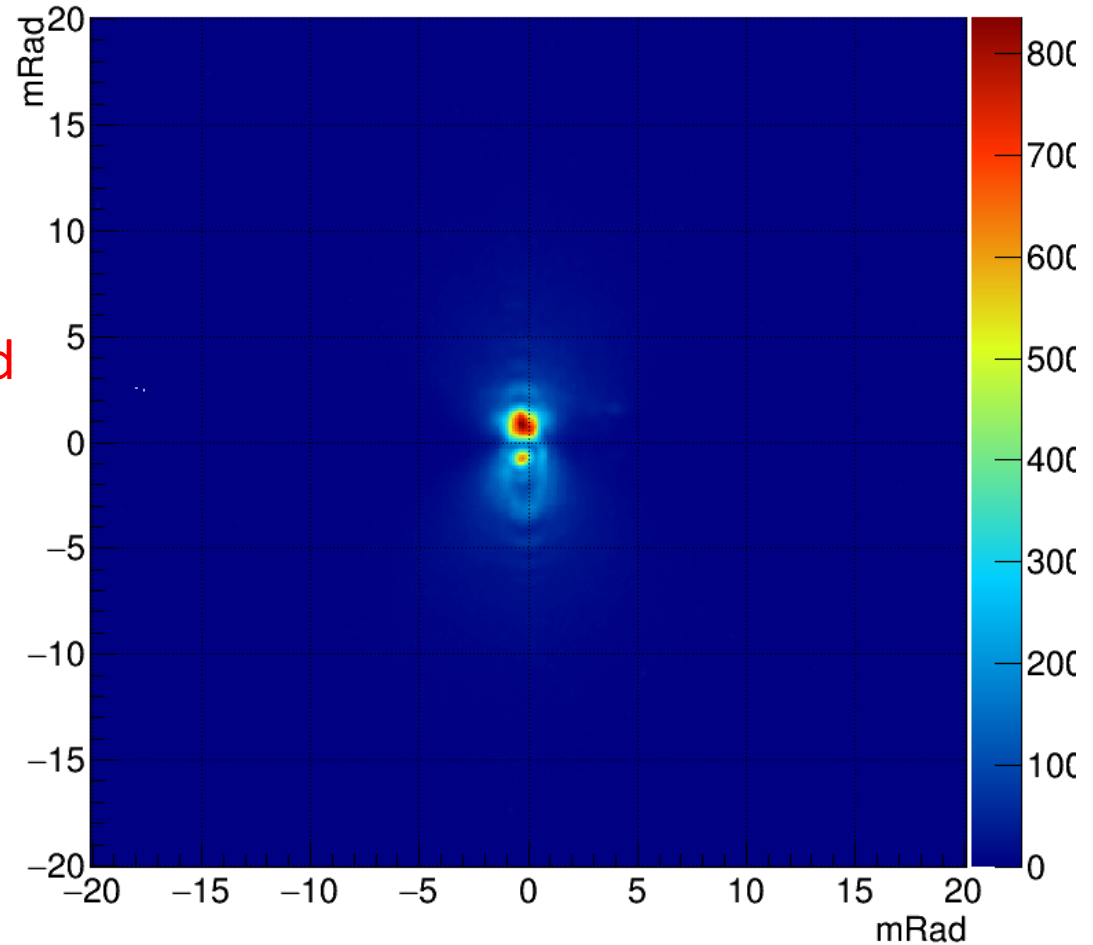


Synchrotron Radiation Contribution at ATF2

Angular distribution

Insertion of the mask
(582 μm aperture)

Although mask is inserted
there is a strong
Interference between
Synchrotron Radiation
and Transition Radiation
because beam is not
centered in the
quadrupole (QM14FF)
before the target.

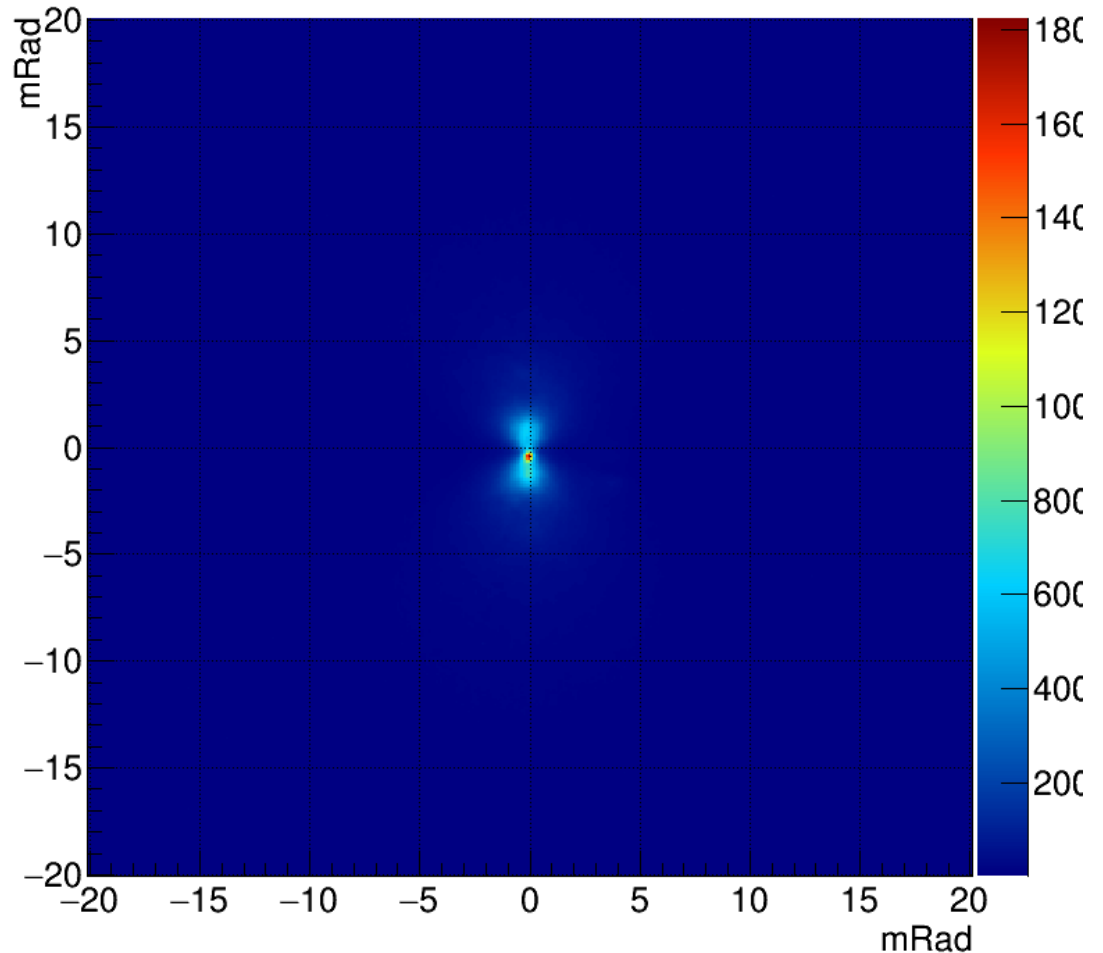


Synchrotron Radiation Contribution at ATF2

Angular distribution

No mask present,
Alignment of the
quadrupole magnet
present before the
target (QM14FF)

Better profile but peak
present in the middle
of the pattern due to
Synchrotron Radiation
generated upstream in
the beam-line

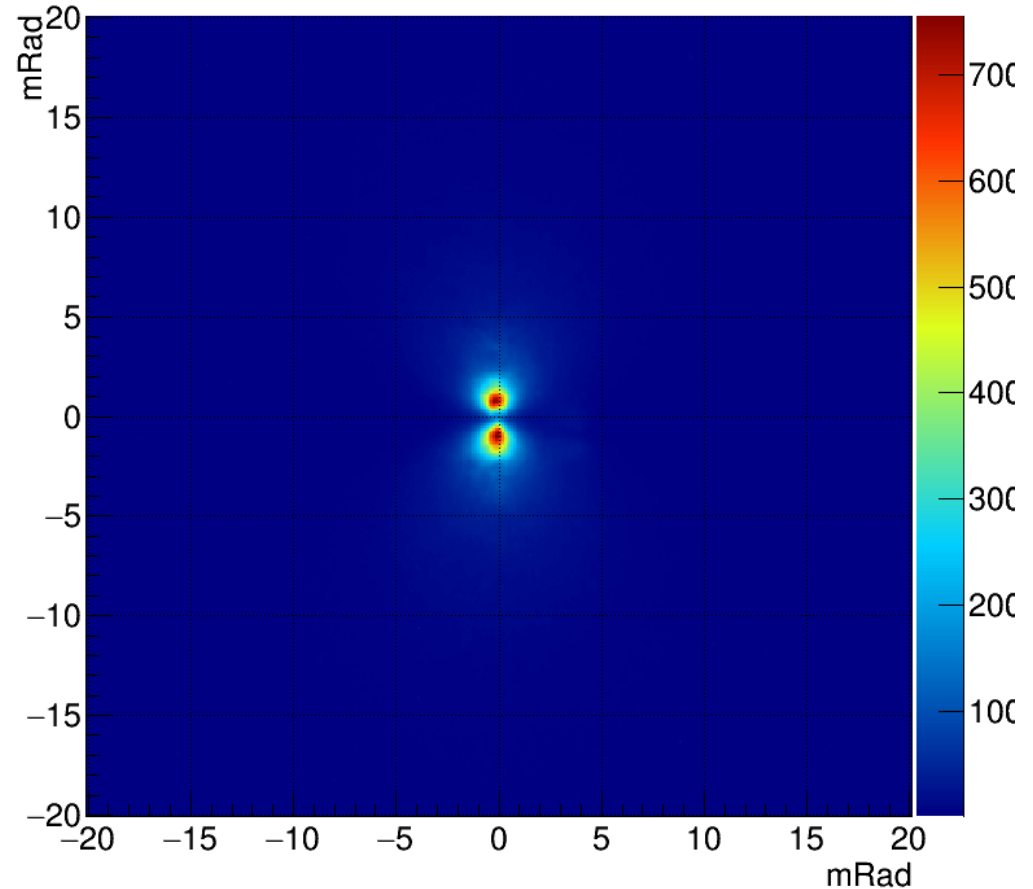


Synchrotron Radiation Contribution at ATF2

Angular distribution

Re insertion of the
mask (582 μm)

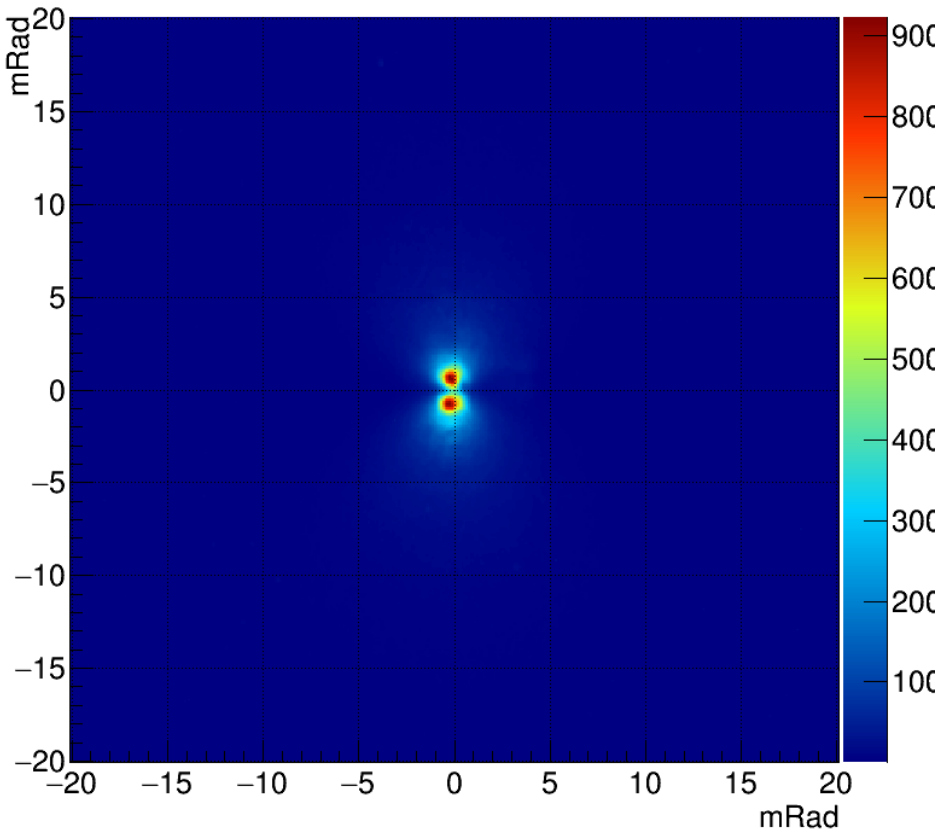
Maximum reduction of
the Synchrotron
Radiation Contribution



Synchrotron Radiation Contribution at ATF2

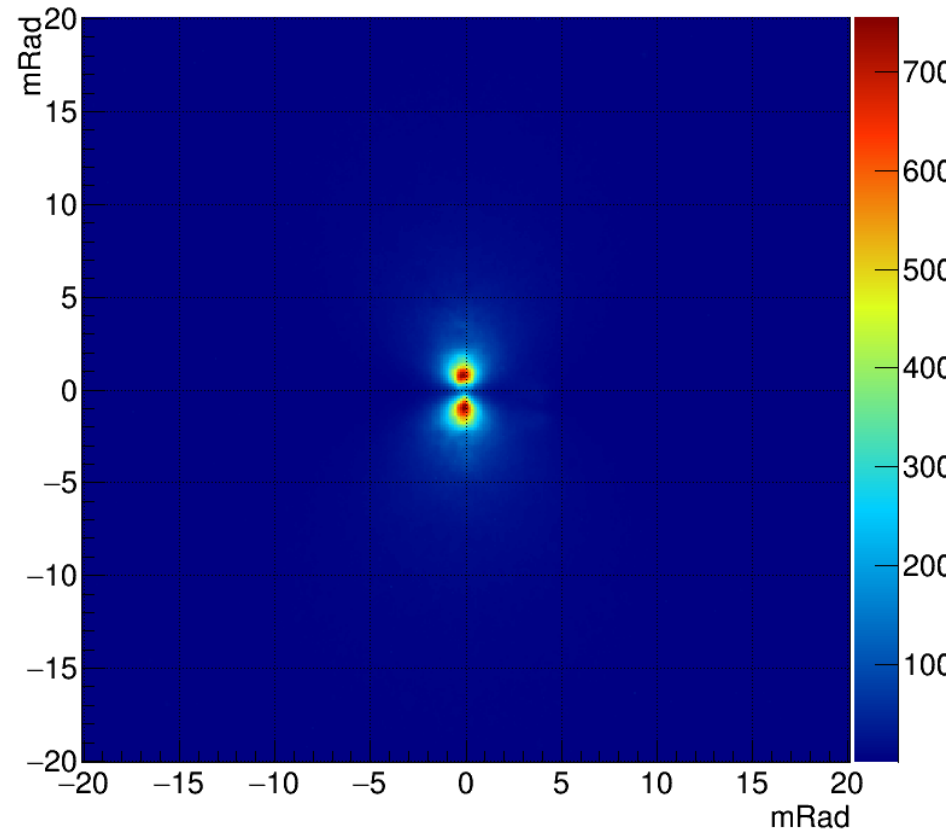
Before beam line optimization

Angular distribution



After beam line optimization

Angular distribution

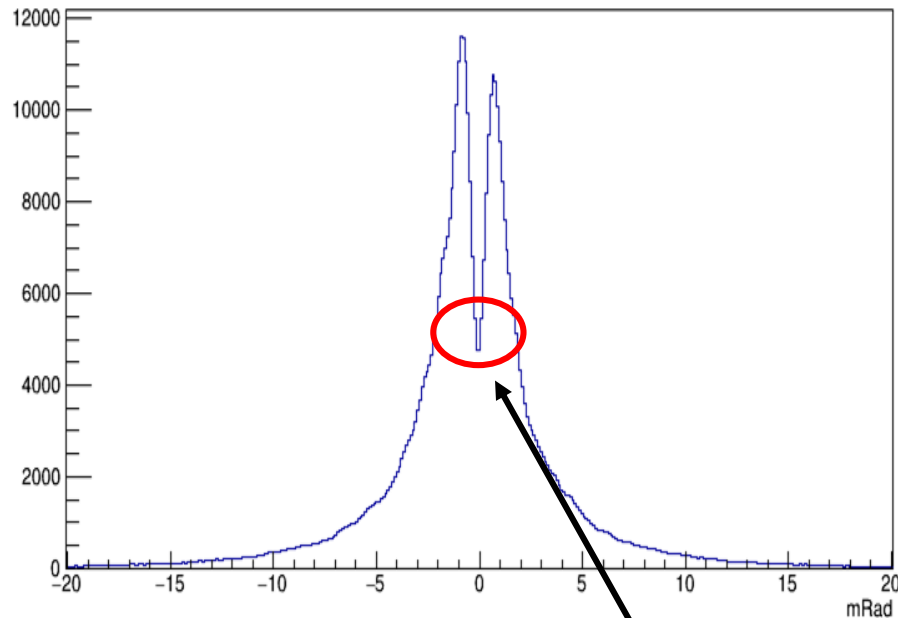


Synchrotron Radiation Contribution at ATF2

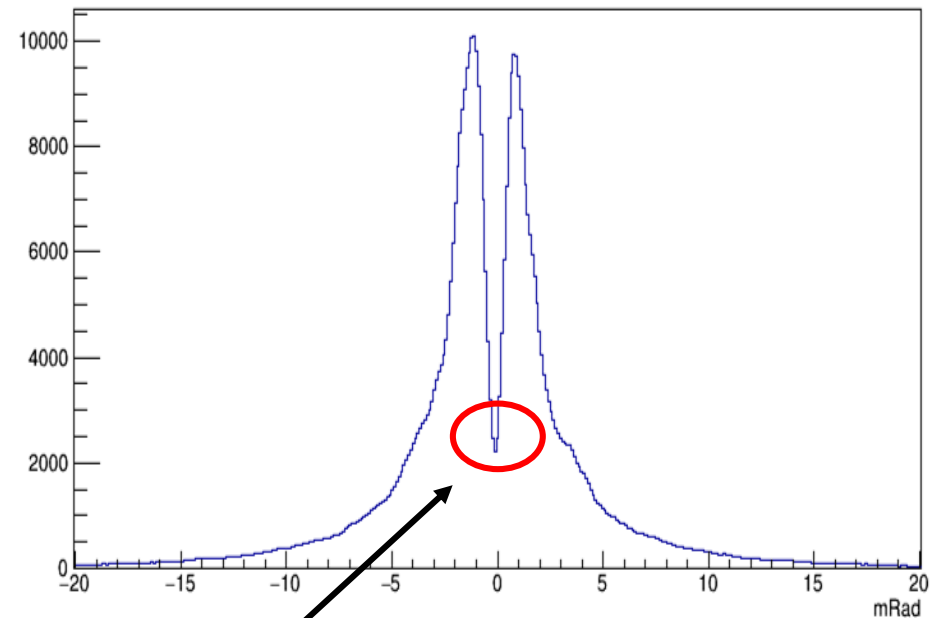
Before beam line optimization

After beam line optimization

Vertical projected Slice



Vertical projected Slice

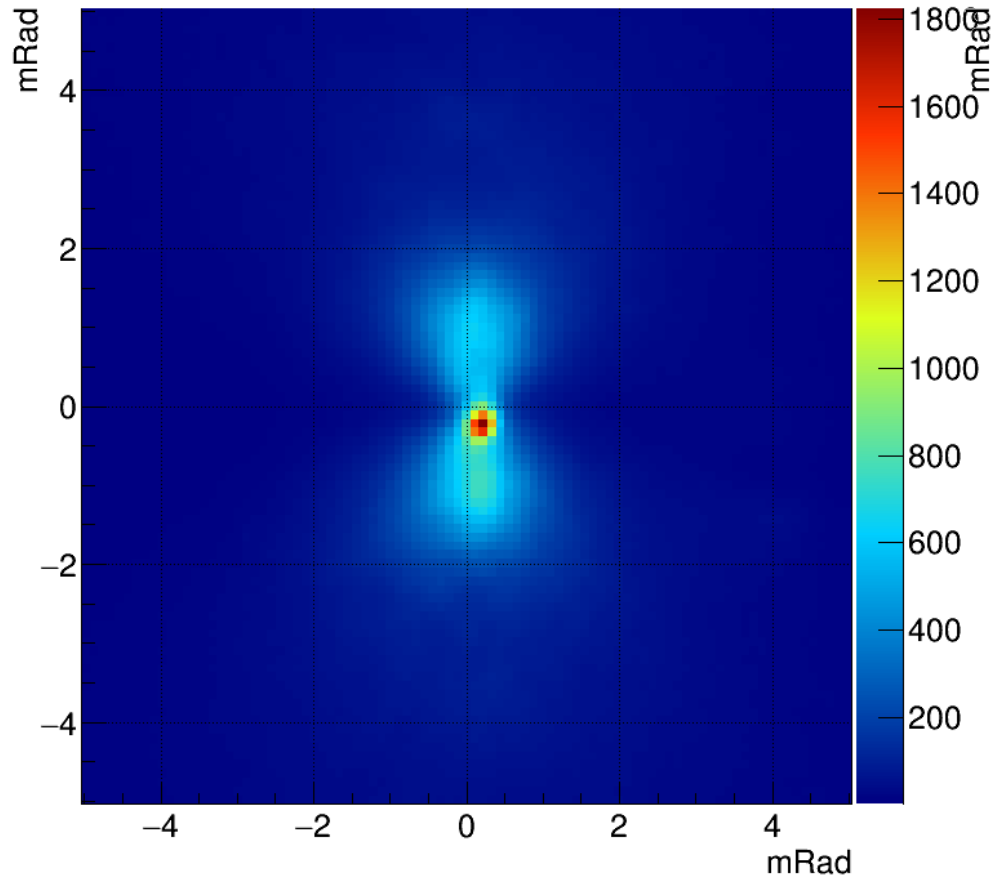


Lower minimum = lower SR Contribution

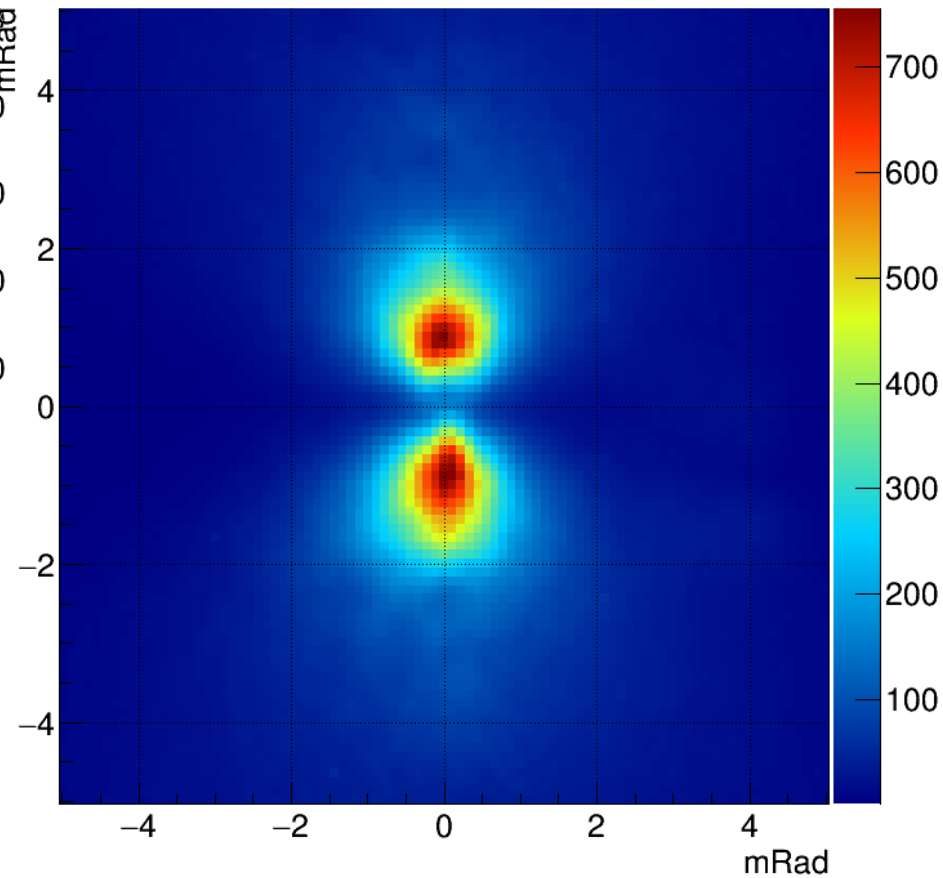
Binning limit the minima => bigger angular magnification needed

Synchrotron Radiation Contribution at ATF2

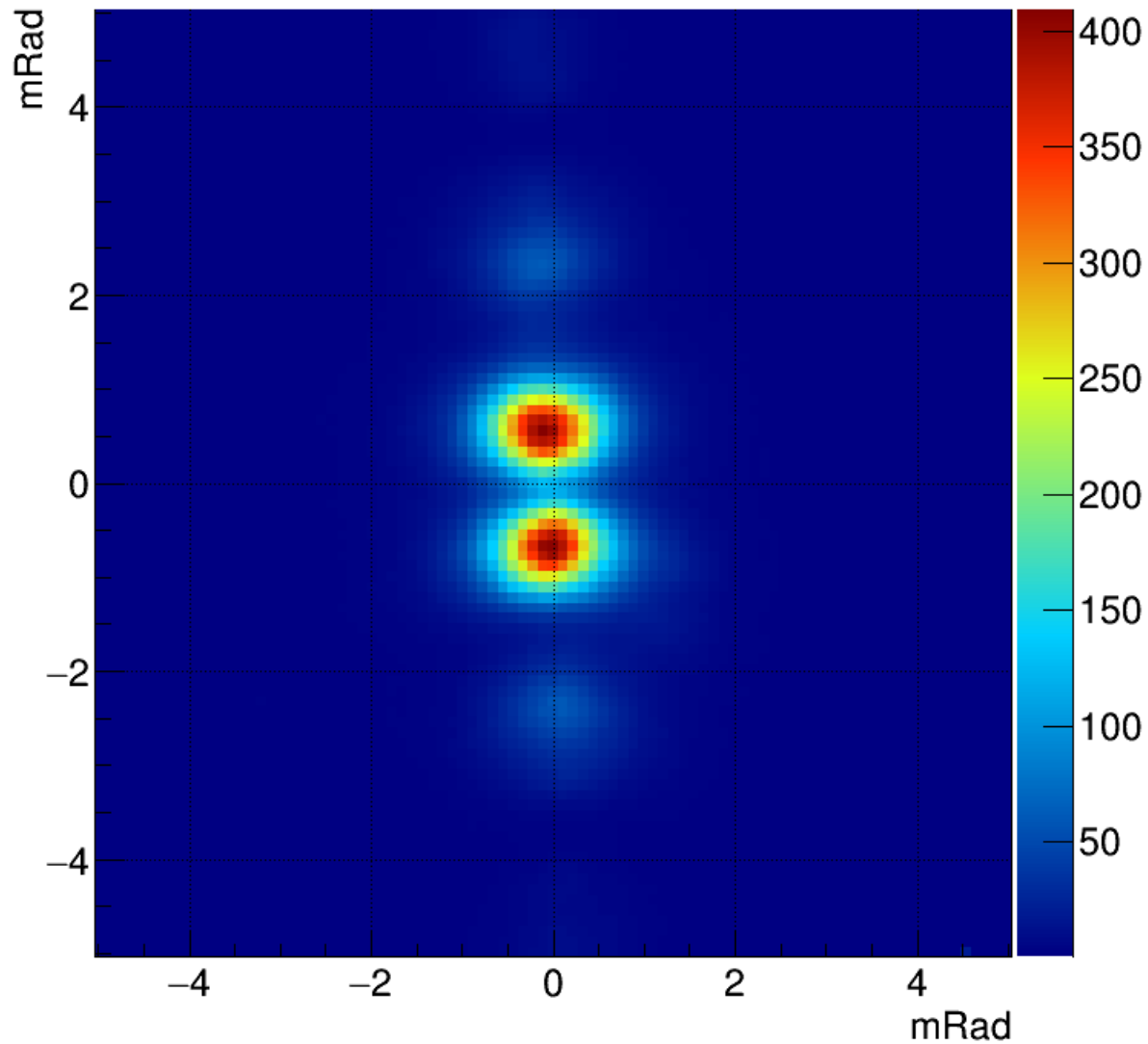
TR 2D profile **without** mask



TR 2D profile **with** mask



ODRI 2D angular intensity



$\lambda = 450 \text{ nm}$, beam size = $15.0 \mu\text{m}$,
mask = $582.0 \mu\text{m}$, target = $201.7 \mu\text{m}$

ODRI simulation

$$E_{y,i} = \left\{ \frac{e^{-[(a_1/2)+z_1](f-ik_y)}}{f-ik_y} - \frac{e^{-[(a_1/2)-z_1](f+ik_y)}}{f+ik_y} \right\} - e^{i\Phi_0} \left\{ \frac{e^{-[(a_2/2)+z_2](f-ik_y)}}{f-ik_y} - \frac{e^{-[(a_2/2)-z_2](f+ik_y)}}{f+ik_y} \right\} [1]$$

With a_1 mask slit aperture, a_2 target slit aperture, z_1 and z_2 particle position at mask and slit, γ relativistic factor, λ observation wavelength, β ratio between the particle velocity and the speed of light, $k = (2\pi/\lambda)$, $\eta = (k/\beta\lambda)$, $f = \sqrt{k_x^2 + \eta^2}$, $k_x = k \sin \theta \cos \phi$, $k_y = k \sin \theta \sin \phi$, $\Phi_0 = \eta d(1 - \beta \cos \theta)$, θ and ϕ angular coordinates in the observation plane.



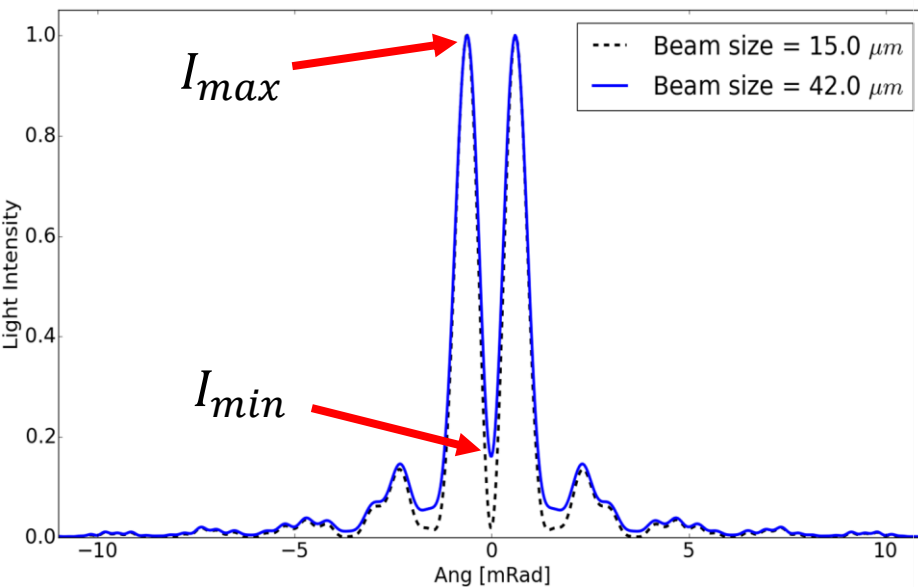
[1] A. Cianchi et al., *Non-intercepting electron beam size monitor using optical diffraction radiation interference*, Phys. Rev. ST Accel. Beams 14,102803 (2011)



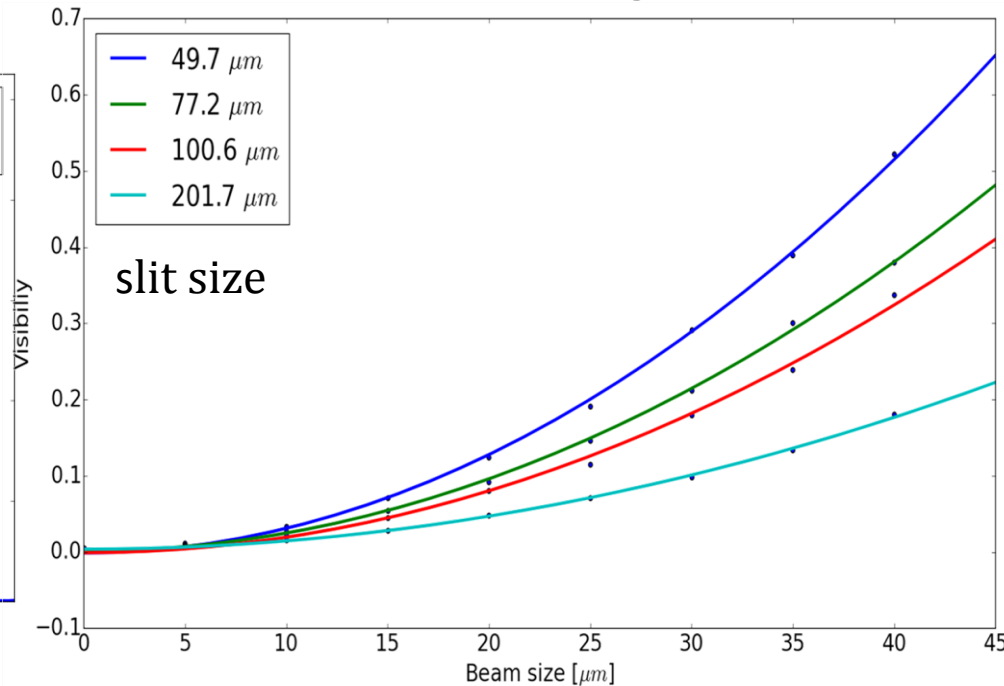
ODRI simulation

$$I = \sum_i^n E_{y,i}^2 \quad n = 5000$$
$$d = 130 \text{ mm}$$

Projected Vertical Polarization Component (PVPC) [2] of DR angular Intensity for 2 beam sizes



Simulated Visibility vs Gaussian beam size for different target slit sizes



$\lambda = 450 \text{ nm}$, mask = 582.0 μm , target = 201.7 μm

$$\text{Visibility} = I_{min}/I_{max}$$

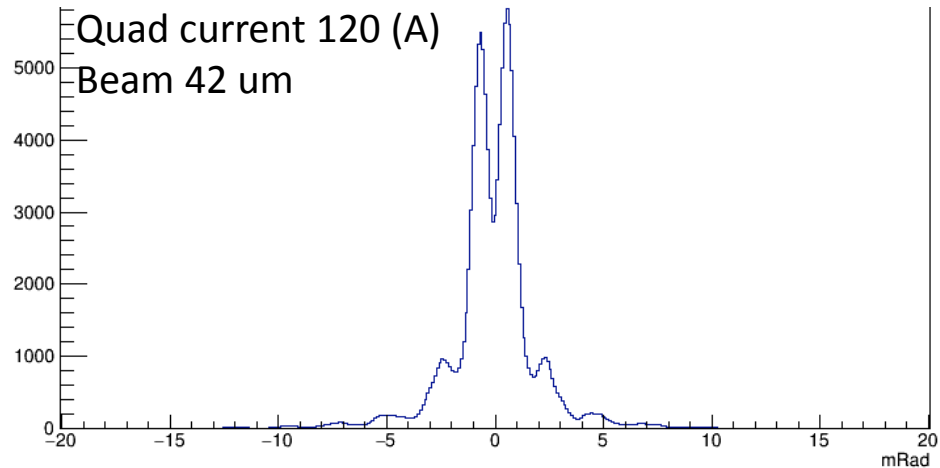
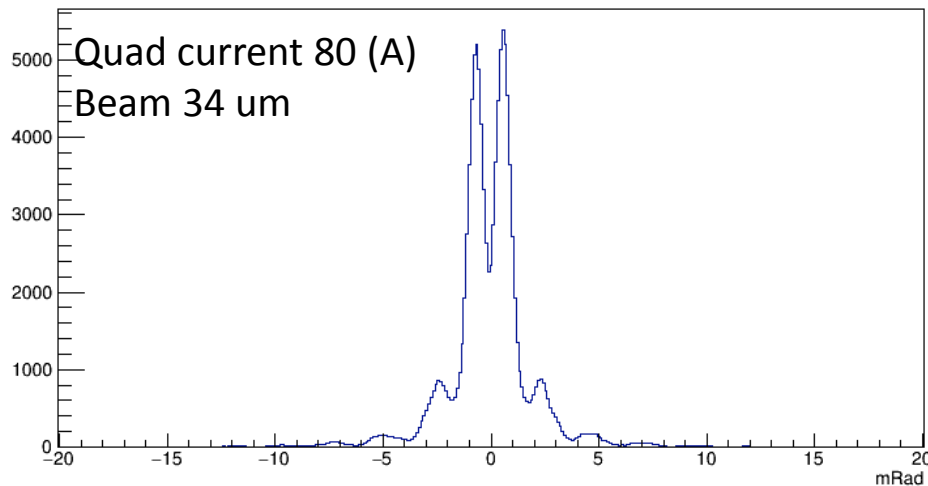
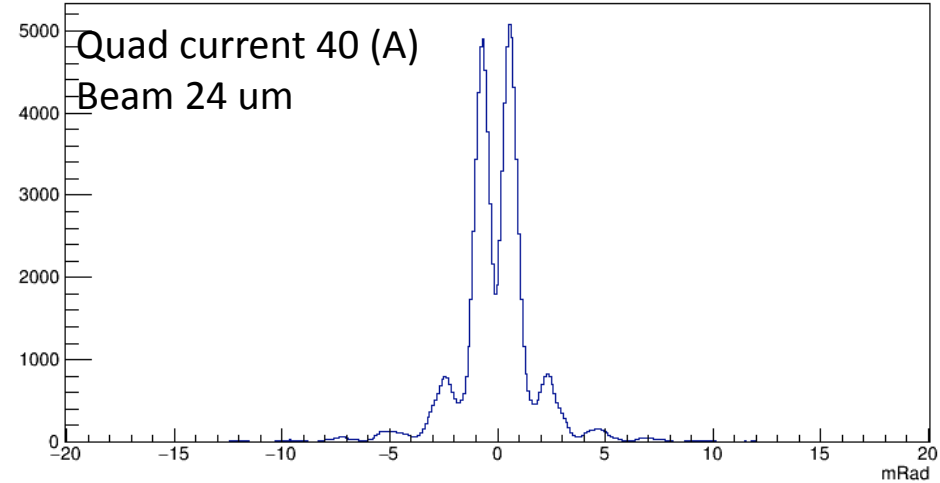
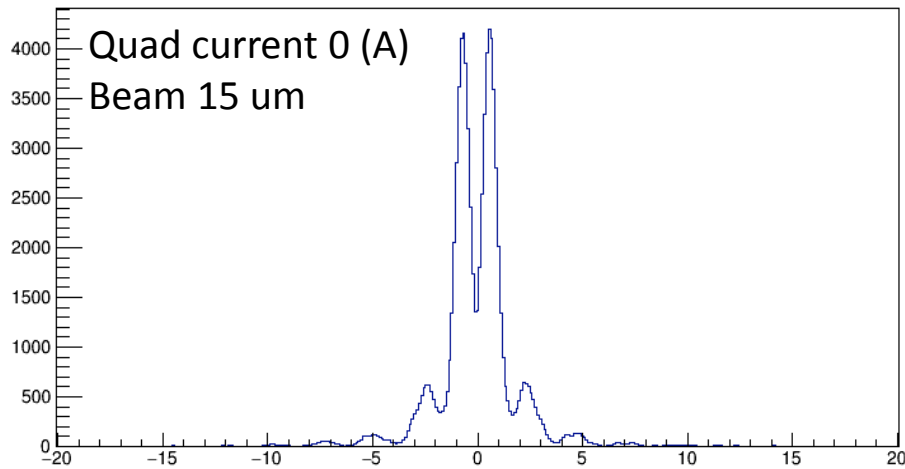


[2] P. Karataev, et al, *Beam Size Measurements with Optical Diffraction Radiation at KEK Accelerator Test Facility*, Phys. Rev. Lett. 93, 244802 (2004)



ODRI visibility Quad Scan

PVPC of DR angular intensity for different beam sizes



Filter: 450nm Slit: 201.7 μm Mask: 582 μm

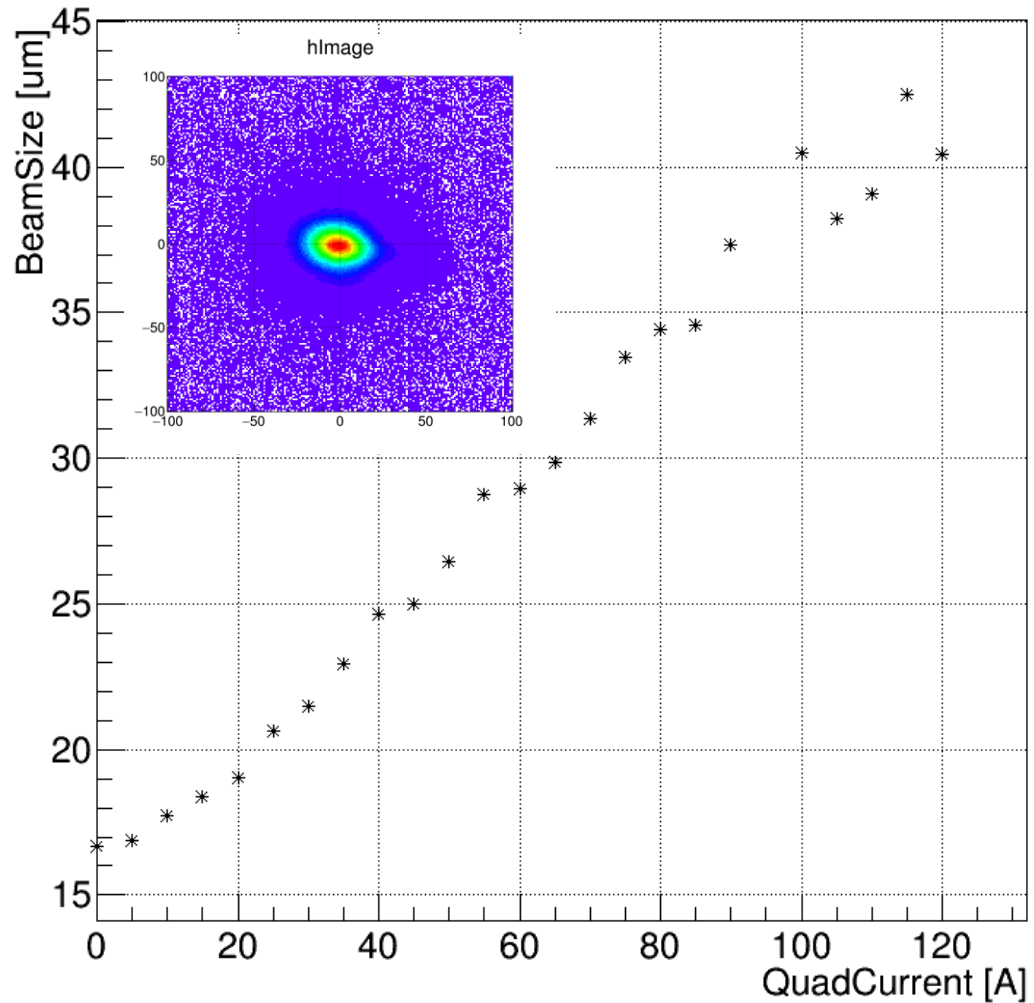
OTR Beam size calibration

OTR_HorizontalPolarization_for_ODR_BeamSize_Calibration

The side mirrors of the ODR slit were used to record reference OTR beam size measurement.

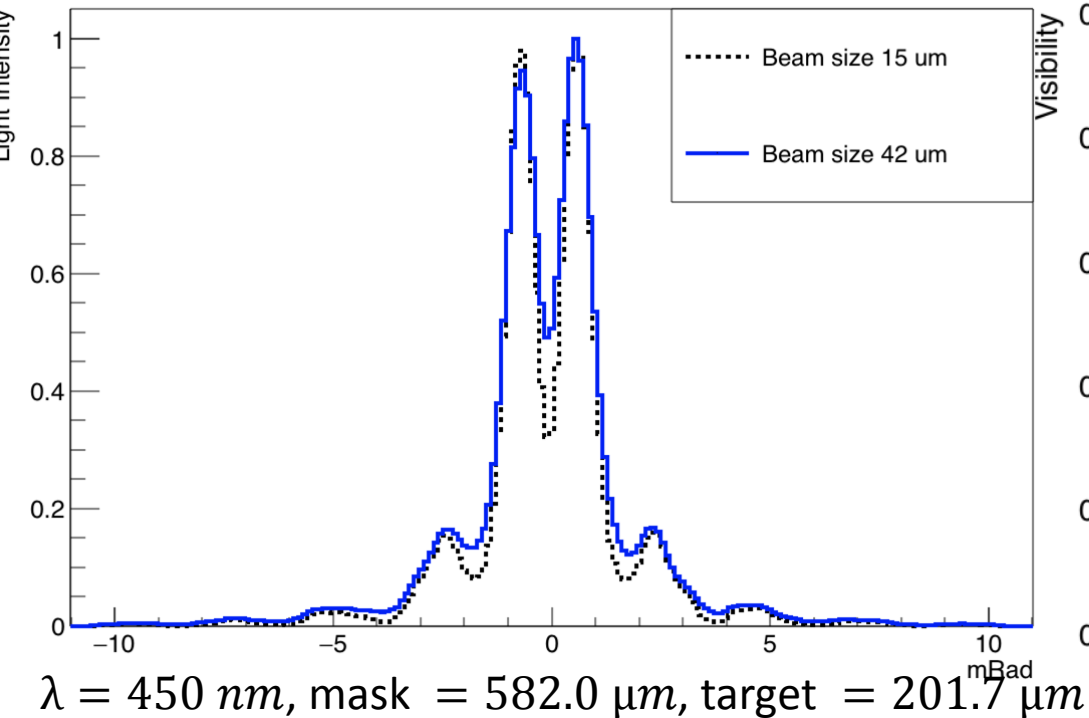
This could be done in CLIC/ILC using pilot beam (no target damage).

Then ODR can then be used for full beam charge.

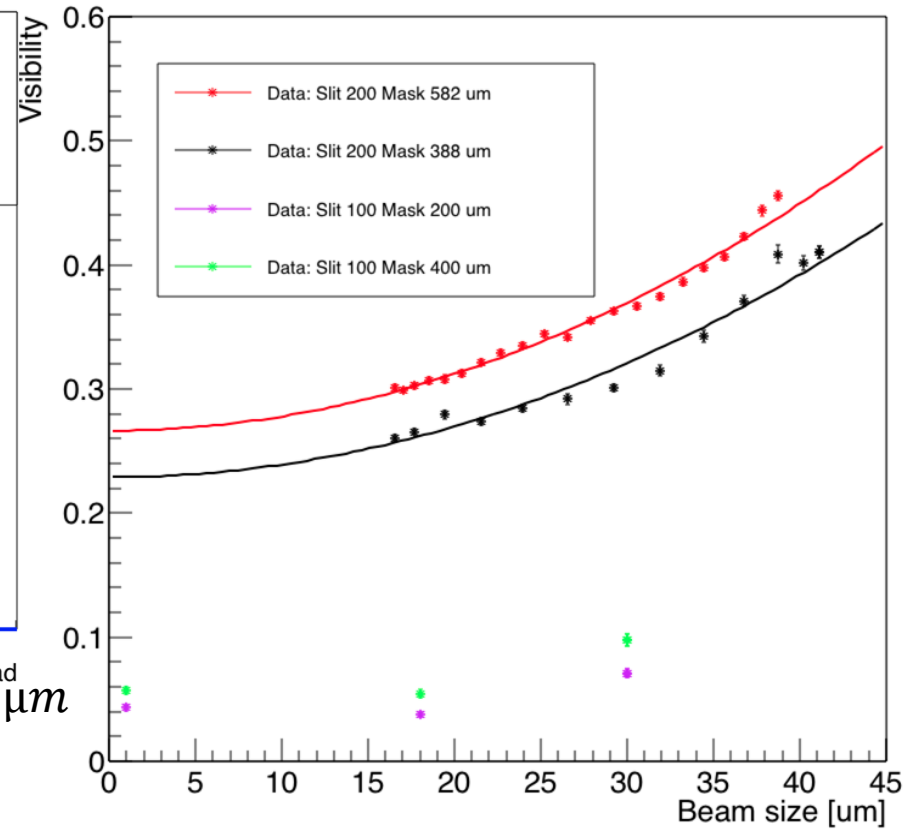


ODRI angular intensity

PVPC of DR angular intensity
for 2 beam sizes

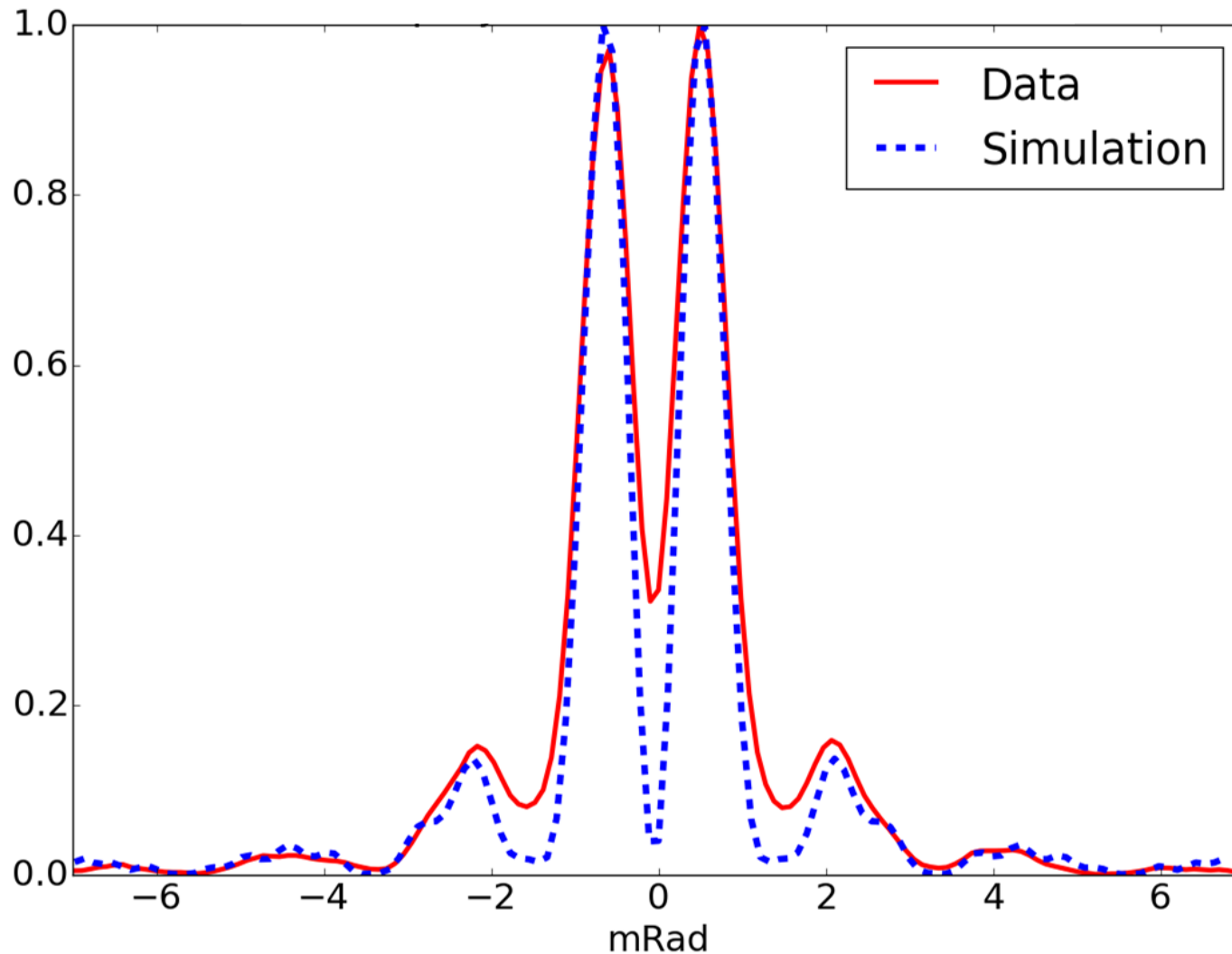


Measured Visibility for different
beam sizes and mask/target
combination



ODR angular data vs simulation

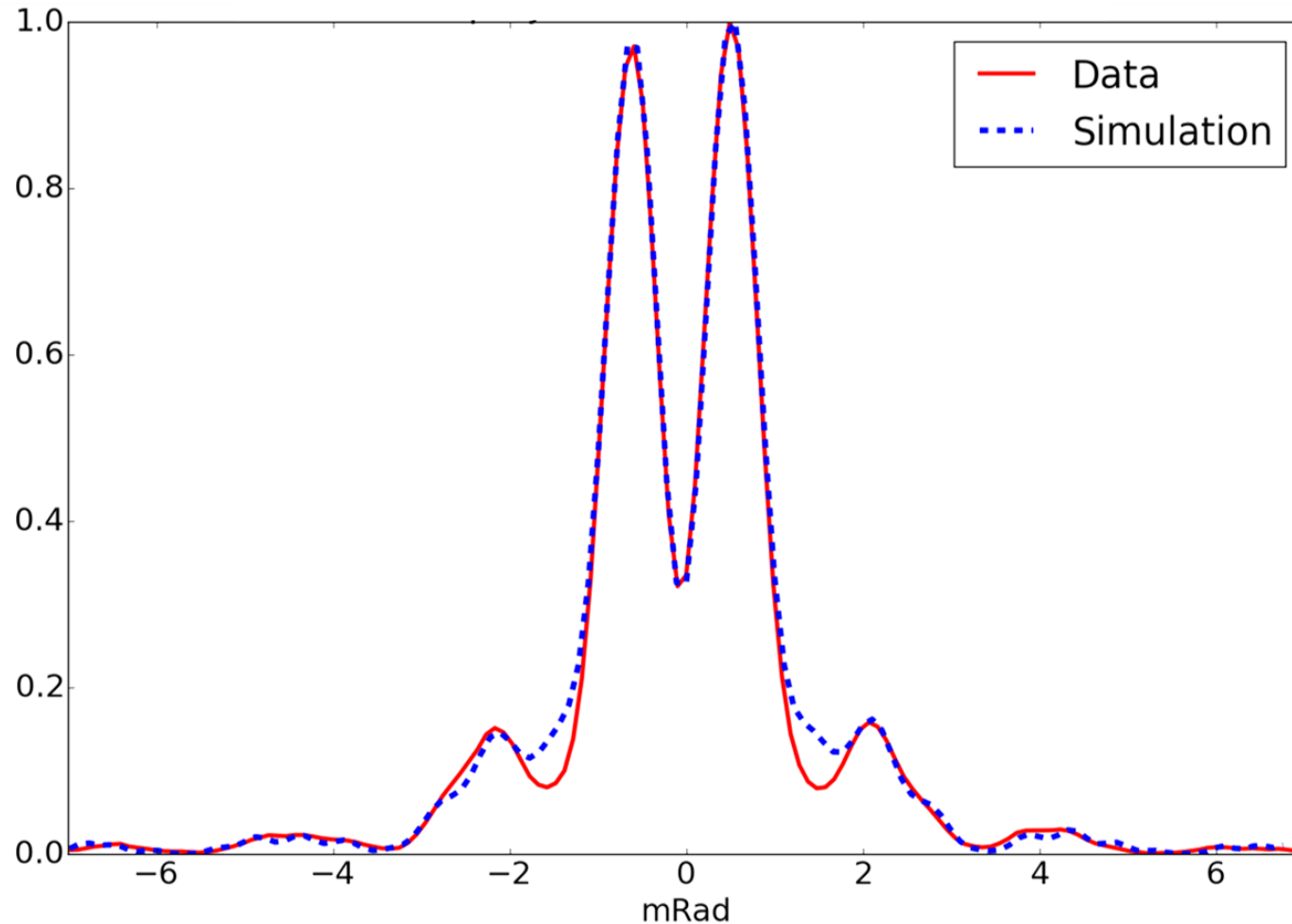
$\sigma = 15 \mu m$, $\lambda = 450 \text{ nm}$, mask = 582.0 μm , target = 201.7 μm



ODR angular data vs simulation

Synchrotron background Gaussian + 6 μm offset in the vertical alignment between slit and mask

$\sigma = 15 \mu\text{m}$, $\lambda = 450 \text{ nm}$, mask = 582.0 μm , target = 201.7 μm

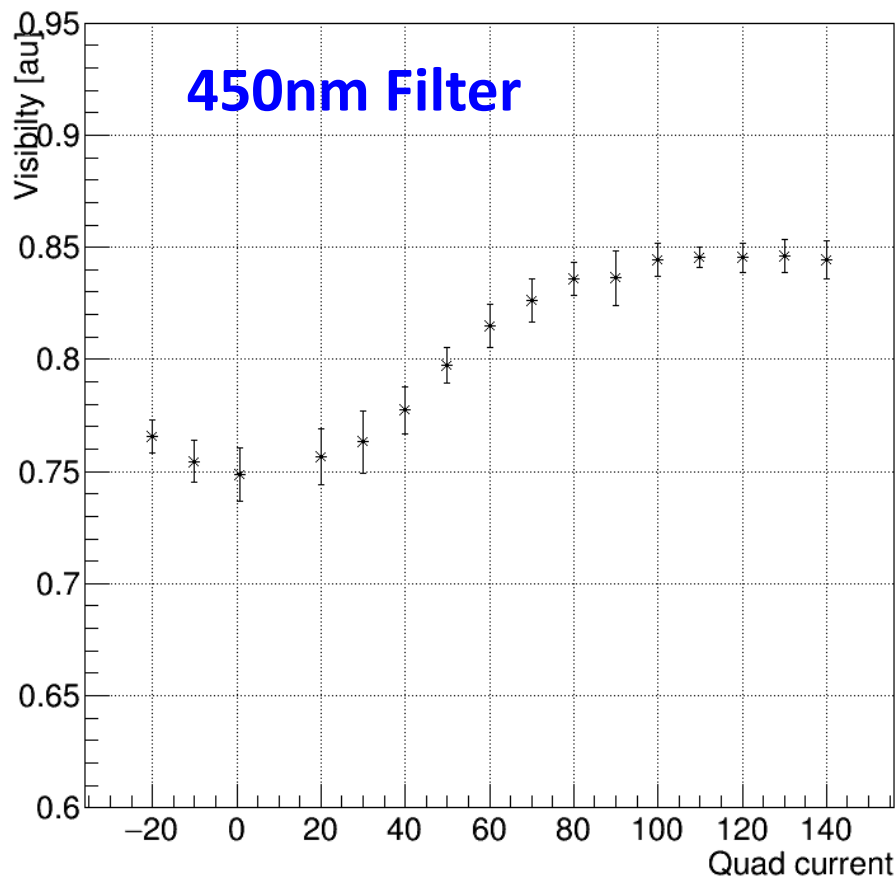
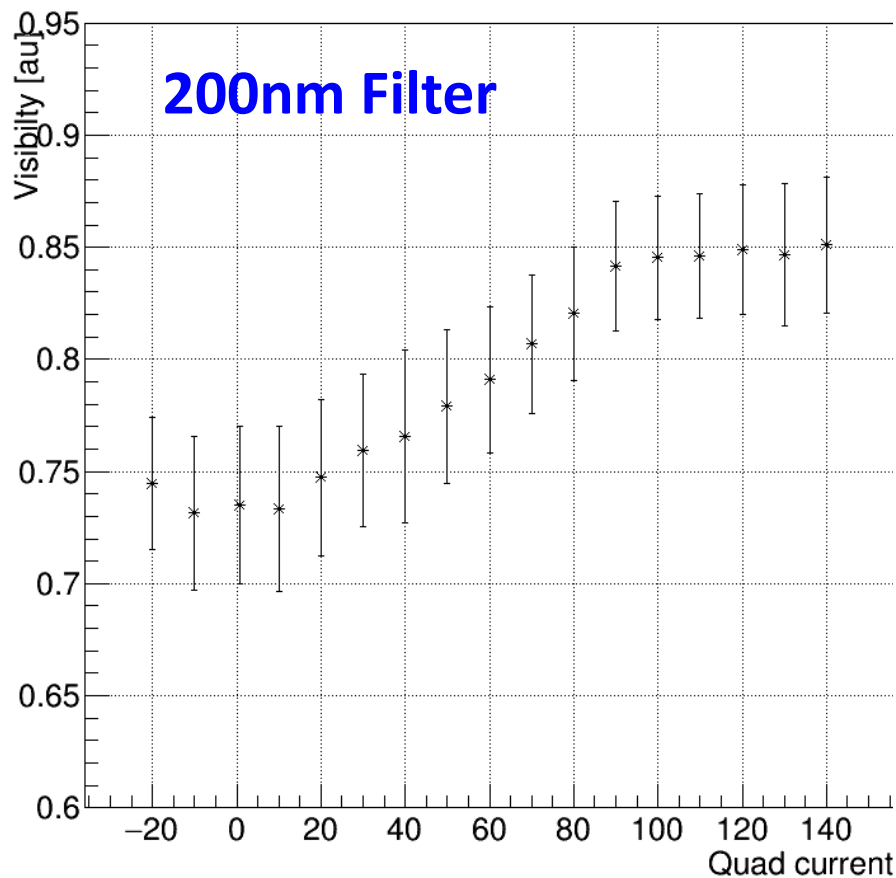


ODR angular data

Visibilty

Last shifts results

Visibilty



mask = 100 μm , target = 77.2 μm

Minimum beam size around 5 μm (not calibrated, OTR PSF)